

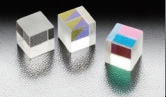
Beamsplitters



Beamsplitters Selection Guide

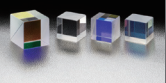
B045

Half Mirror Cube



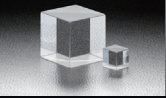
Non-polarizing Cube Half Mirrors
NPCH

B046



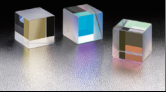
Hybrid Cube Half Mirrors
HBCH

B048



Chromium Cube Half Mirrors
CSCH

B049



Dielectric Cube Half Mirrors
CSMH

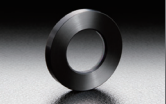
B050

Half Mirror Plate



Ultra Broadband Dielectric Half Mirrors
PMH/PSMH

B052



Thin Plate Beamsplitter
MPSMH

B054



Laser Line Plate Half Mirrors
PSMH

B055



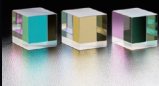
Chromium Plate Half Mirrors
PSCH

B058

Application Note

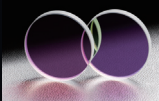
B059

Beamsplitters



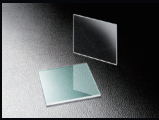
Dielectric Cube Beamsplitters
CSM

B060



Dielectric Plate Beamsplitters
PSM

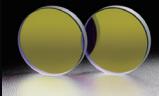
B061



Variable Beamsplitter
Light path corrector
VBS/WSQNA/WBNA

B062

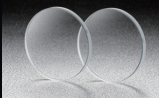
Harmonic Separators



Harmonic Separators
YHS

B064

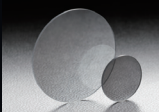
Beam Samplers



Beam Samplers
BS4

B066

Others



Polka dot beam splitter
PDBS

B067



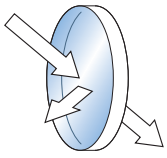
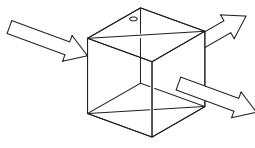
Pellicle beam splitter
PELL

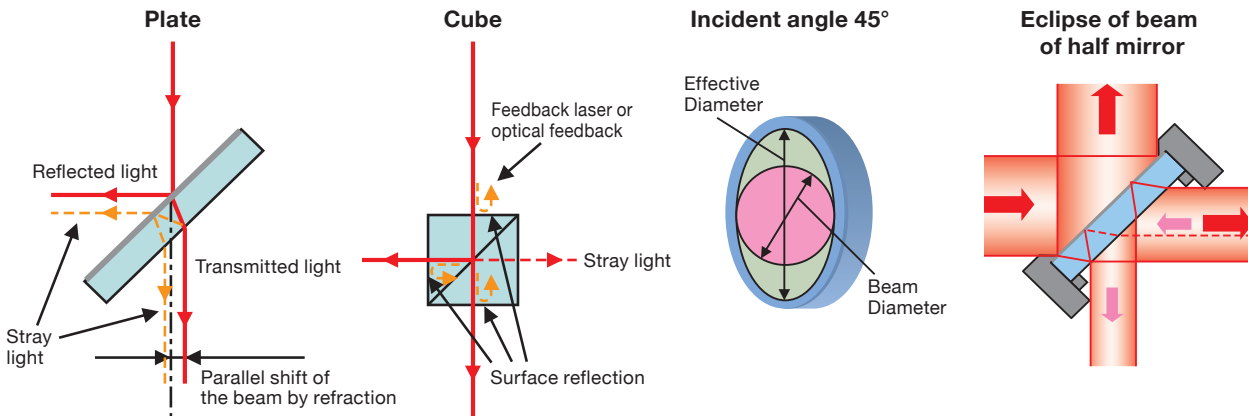
B068

Beamsplitters selection Guide

A beamsplitter is an optic that splits light into 2 directions. The split ratio of light transmittance and reflectance is 1:1 and is called a half mirror.

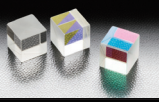
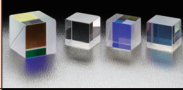



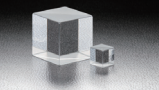
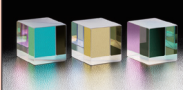
The 2 forms of beamsplitters are cube and plate type.

| Type | Affected products | Features | Application |
|--------------|---|--|---|
| Plate |  | Good fit for large beam size applications at a reasonable price. Advantages are: minimal back reflection, compact light-path as compared to cube type beamsplitters and low chromatic dispersion. There may be a slight offset of the transmitted beam due to refraction. For 45 degrees incident application, the clear aperture would be elliptical. There may be some vignetting on angle of incidence. | Large beam size optical set up. Used in large beam size optical layouts. Used for monitoring optical systems, split beams into different wavelengths, polarizations or intensities. |
| Cube |  | Can be applied at its maximum effective area from any incident direction, easy to be applied in optical design and simple for optical set up adjustment. High cost and high weight for large beam size application. Feedback light at less than 1% may happen. The transmittance light through the cube is longer than a plate type, the chromatic dispersion is higher. Eliminates the problem of beam deviation. | For a compact size optical set up. For high accuracy experiment and optical set up usage. |



Experimentation with laser (Linear polarized light)

Lasers are used to evaluate our half mirrors and with the polarization properties of the laser, we are able to check the change of light splitting ratios.

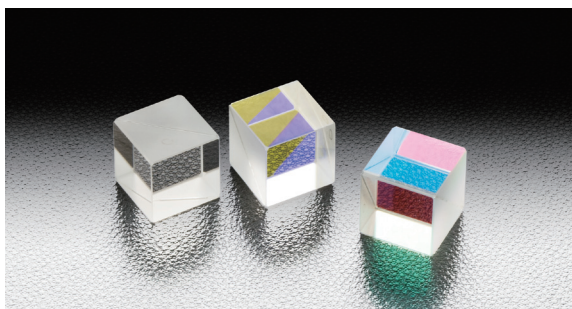
| Type | Affected products | Application | Experimentation with laser (Linear polarized light) | Polarization dependency |
|--|---|---|--|---|
| Non-polarizing (NPCH) Reference B046 |  | For high accuracy laser experiment with accurate light ratios at any polarization levels. | The light ratios at 1:1 stay stable even when the polarization situation changes. No power loss. | Small |
| Hybrid (HBCH) Reference B048 |  | For multi-wavelength light splitting solutions. | Light ratio at 1:1 from any specified light incident direction will remain similar. |  |
| Laser Line Plate (PSMH) Reference B055 |  | Large beam size, multi mirror optical set up with small power light source and supports high power laser light splitting. | Polarization at 45 degree (AOI) or circle polarization light with no power loss detected. | |
| Chromium Plate (PSCH) Reference B058 |  | Large beam size and observation optical system. | Polarization at 45 degree (AOI) or circle polarization light with 36% absorption of light power. | |
| Chromium Cube (CSCCH) Reference B049 |  | For basic laser experiments and compact optical solutions. Great entry level price. | Polarization at 45 degree (AOI) or circle polarization light with 40% absorption of light power. | |
| Dielectric Cube (CSMH) Reference B050 |  | For general white light and non-polarizing light i.e. LED light splitting solutions. | Polarization at 45 degree (AOI) or circle polarization light with no power loss detected. | |
| | | | | |

Non-polarizing Cube Half Mirrors | NPCH

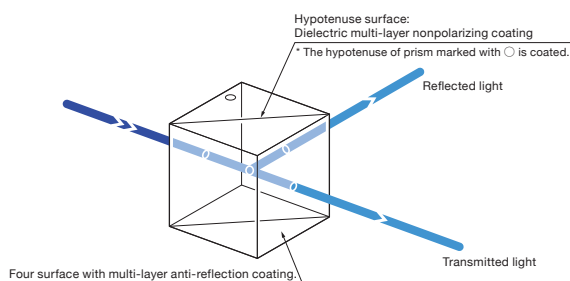
RoHS

This is a half mirror that has an even 1:1 ratio of reflection and transmission in both linear polarized light and normal light source.

- The reflection to transmission ratio is 1:1 regardless of the polarization condition from the input beam.
- Depending on polarization, the reflection to transmission ratio of these products does not vary.
- The laser line corresponds to various wavelengths.
- Narrowband multi-layer AR coatings are applied to the four surfaces of the cube.
- Because the effective bandwidth of a non-polarizing coat is narrow, these products are designed for a single wavelength.

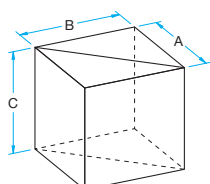


Schematic



Outline Drawing

(in mm)



- Tolerance
- A ± 0.2
- B ± 0.2
- C ± 0.1

Specifications

| | |
|---|--|
| Material | BK7, Synthetic fused silica |
| Surface flatness of substrate | $\lambda/4$ |
| Beam Deviation | $<5'$ |
| Coating | Hypotenuse Surface: Dielectric multi-layer nonpolarizing coating Four Surfaces: Multi-layer anti-reflection coating |
| Incident angle | 0° |
| Divergence ratio (reflectance : transmittance) | 1 : 1 |
| Laser Damage Threshold | 0.3J/cm ² (Laser pulse width 10ns, repetition frequency 20Hz) |
| Surface Quality (Scratch-Dig) | 20-10 |
| Clear aperture | 85% of Circle to actual dimension (80% of actual aperture for 5 and 7mm dimension (A=B=C) products.) |

Guide

- ▶ Please contact our International Sales Division for customized products. (Customized on size, wavelength or R:T, etc.) [Reference](#) B069
- ▶ To produce non-polarizing beam splitter (plate type) is also possible.
- ▶ For a guarantee in reflected wavefront error or transmitted wavefront error, please contact our International Sales Division.

Attention

- ▶ Input beam from the prism side is indicated by a ○.
- ▶ Phase retardation of light input will not be preserved. Use a waveplate for phase compensation.
- ▶ Wavelength dispersion on transmitted and reflected light derives from refraction index and glass thickness. And also, when diverging or introducing a focusing beam, chromatic aberration or spherical aberration may occur.

266 – 532nm

| Part Number | Wavelength Range [nm] | A=B=C [mm] | Material | Transmittance [%] |
|--------------|-----------------------|------------|------------------------|-------------------|
| NPCH-10-2660 | 266 | 10 | Synthetic fused silica | 50±10 |
| NPCH-15-2660 | 266 | 15 | Synthetic fused silica | 50±10 |
| NPCH-20-2660 | 266 | 20 | Synthetic fused silica | 50±10 |
| NPCH-10-3550 | 355 | 10 | Synthetic fused silica | 50±7 |
| NPCH-15-3550 | 355 | 15 | Synthetic fused silica | 50±7 |
| NPCH-20-3550 | 355 | 20 | Synthetic fused silica | 50±7 |
| NPCH-10-4050 | 405 | 10 | BK7 | 50±7 |
| NPCH-15-4050 | 405 | 15 | BK7 | 50±7 |
| NPCH-20-4050 | 405 | 20 | BK7 | 50±7 |
| NPCH-10-4880 | 488 | 10 | BK7 | 50±5 |
| NPCH-15-4880 | 488 | 15 | BK7 | 50±5 |
| NPCH-20-4880 | 488 | 20 | BK7 | 50±5 |
| NPCH-10-5145 | 514.5 | 10 | BK7 | 50±5 |
| NPCH-15-5145 | 514.5 | 15 | BK7 | 50±5 |
| NPCH-20-5145 | 514.5 | 20 | BK7 | 50±5 |
| NPCH-10-5320 | 532 | 10 | BK7 | 50±5 |
| NPCH-15-5320 | 532 | 15 | BK7 | 50±5 |
| NPCH-20-5320 | 532 | 20 | BK7 | 50±5 |

Compatible Optic Mounts

PLH-25, -40 / KKD-25PHRO, -40PHRO

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Half Mirror Plate

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Harmonic Separator

Beam Samplers

Others

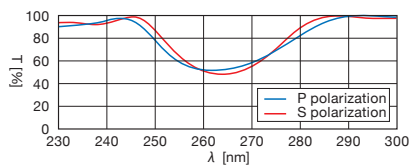
Cube Type: Nonpolarizing 632.8 – 1550nm

| Part Number | Wavelength Range [nm] | A=B=C [mm] | Material | Transmittance [%] |
|---------------|-----------------------|------------|----------|-------------------|
| NPCH-05-6328 | 632.8 | 5 | BK7 | 50±5 |
| NPCH-10-6328 | 632.8 | 10 | BK7 | 50±5 |
| NPCH-15-6328 | 632.8 | 15 | BK7 | 50±5 |
| NPCH-20-6328 | 632.8 | 20 | BK7 | 50±5 |
| NPCH-10-6700 | 670 | 10 | BK7 | 50±5 |
| NPCH-15-6700 | 670 | 15 | BK7 | 50±5 |
| NPCH-20-6700 | 670 | 20 | BK7 | 50±5 |
| NPCH-10-7800 | 780 | 10 | BK7 | 50±5 |
| NPCH-15-7800 | 780 | 15 | BK7 | 50±5 |
| NPCH-20-7800 | 780 | 20 | BK7 | 50±5 |
| NPCH-10-8300 | 830 | 10 | BK7 | 50±5 |
| NPCH-15-8300 | 830 | 15 | BK7 | 50±5 |
| NPCH-20-8300 | 830 | 20 | BK7 | 50±5 |
| NPCH-10-10640 | 1064 | 10 | BK7 | 50±5 |
| NPCH-15-10640 | 1064 | 15 | BK7 | 50±5 |
| NPCH-20-10640 | 1064 | 20 | BK7 | 50±5 |
| NPCH-10-13000 | 1300 | 10 | BK7 | 50±5 |
| NPCH-15-13000 | 1300 | 15 | BK7 | 50±5 |
| NPCH-20-13000 | 1300 | 20 | BK7 | 50±5 |
| NPCH-10-15500 | 1550 | 10 | BK7 | 50±5 |
| NPCH-15-15500 | 1550 | 15 | BK7 | 50±5 |
| NPCH-20-15500 | 1550 | 20 | BK7 | 50±5 |

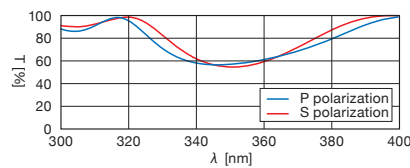
Typical Transmittance Data

T: Transmission

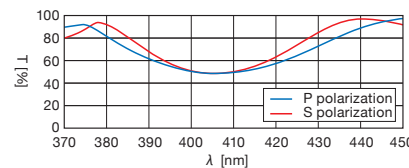
NPCH-2660



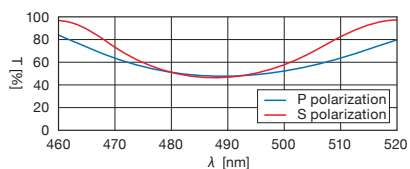
NPCH-3550



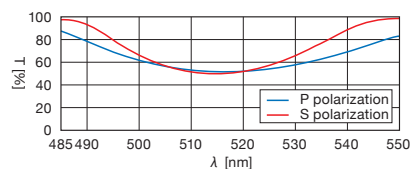
NPCH-4050



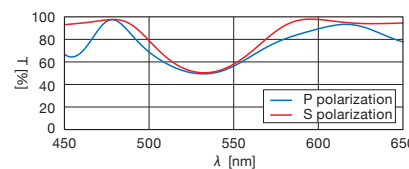
NPCH-4880



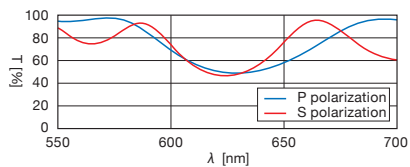
NPCH-5145



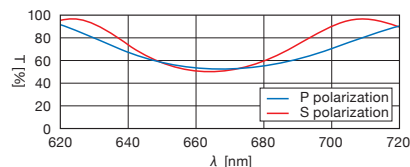
NPCH-5320



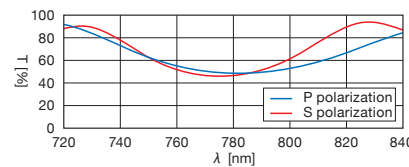
NPCH-6328



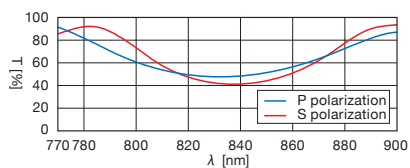
NPCH-6700



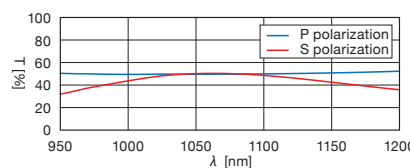
NPCH-7800



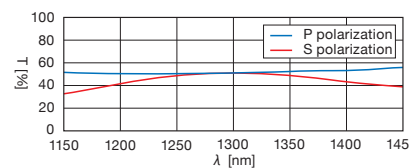
NPCH-8300



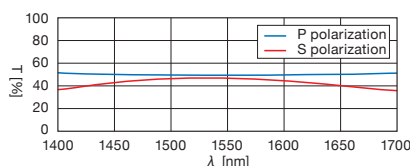
NPCH-10640



NPCH-13000



NPCH-15500



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Beam Samplers

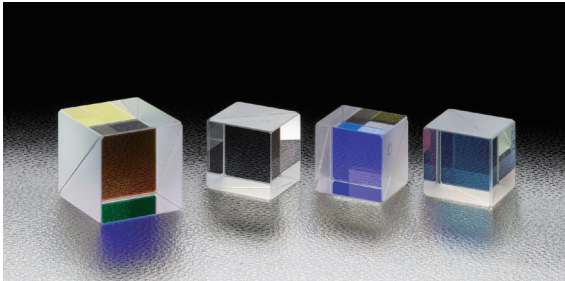
Others

Hybrid Cube Half Mirrors | HBCH

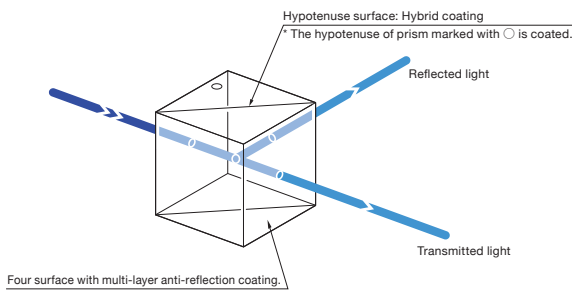
RoHS Catalog Code W3013

Low polarizing cube half mirrors that can be used for broadband visible and infrared light. Applicable for polarizing systems and lasers with multiple wavelength or visible light.

- This hybrid coating is consisting of dielectric multi-layer and metallic coatings. The result is low polarizing and broadband.
- As it is cube shaped, there will not be any lateral shift of the optical axis when a normal incident beam is applied. During transmission and reflection of lights, the aperture remains unchanged.
- Even when the orientation of linear polarization has been changed, beams are equally divided as reflected (R) : transmitted (T) (ratio is 1:1)

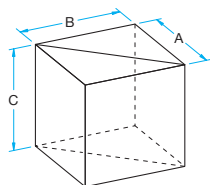


Schematic



Outline Drawing

(in mm)



- Tolerance
- A ± 0.2
- B ± 0.2
- C ± 0.2

Specifications

| | |
|--|--|
| Material | BK7 |
| Surface flatness of substrate | $\lambda/4$ |
| Beam Deviation | <5' |
| Coating | Hypotenuse surface: Hybrid coating (dielectric multi-layer coating and metallic coating) Four surfaces: Multi-layer anti-reflection coating |
| Incident angle | 0° |
| Divergence ratio (reflectance : transmittance) | 1 : 1 |
| Laser Damage Threshold | 0.3J/cm ² (Laser pulse width 10ns, repetition frequency 20Hz) |
| Surface Quality (Scratch-Dig) | 40-20 |
| Clear aperture | 85% of actual dimension |

Guide

- ▶ Please contact our International Sales Division for customized products. (Customized on size, wavelength or R:T, etc.) [Reference](#) B069
- ▶ For a guarantee in reflected wavefront error or transmitted wavefront error, please contact our International Sales Division.

Attention

- ▶ Input beam from the prism side is indicated by a ○.
- ▶ Reflection and refraction over wavelength will differ when light input is applied from the opposite side of the prism.
- ▶ Approximately 10% to 15% of absorption occurs in hybrid coating due to the properties in metallic coating. Hence, any additional transmitted or reflected light will not achieve 100%.
- ▶ Phase retardation of light input will not be preserved. Use a waveplate for phase compensation.
- ▶ Wavelength dispersion on transmitted and reflected light derives from refraction index and glass thickness. And also, when diverging or introducing a focusing beam, chromatic aberration or spherical aberration may occur.

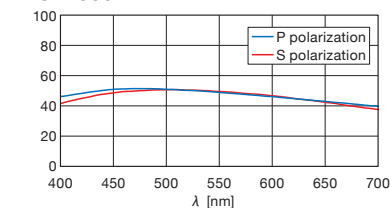
Specifications

| Part Number | Wavelength Range [nm] | A=B=C [mm] | Transmittance [%] | Polarization dependency Tp-Ts [%] |
|-------------|-----------------------|------------|-------------------|---------------------------------------|
| HBCH-10-550 | 400 - 700 | 10 | 45±10 (550nm) | <10 |
| HBCH-15-550 | 400 - 700 | 15 | 45±10 (550nm) | <10 |
| HBCH-20-550 | 400 - 700 | 20 | 45±10 (550nm) | <10 |
| HBCH-10-NIR | 700 - 1100 | 10 | 47±10 (900nm) | <20 (<10: 800 - 1100nm) |
| HBCH-15-NIR | 700 - 1100 | 15 | 47±10 (900nm) | <20 (<10: 800 - 1100nm) |
| HBCH-20-NIR | 700 - 1100 | 20 | 47±10 (900nm) | <20 (<10: 800 - 1100nm) |
| HBCH-10-IR | 1300 - 1550 | 10 | 45±10 (1400nm) | <10 |
| HBCH-15-IR | 1300 - 1550 | 15 | 45±10 (1400nm) | <10 |
| HBCH-20-IR | 1300 - 1550 | 20 | 45±10 (1400nm) | <10 |

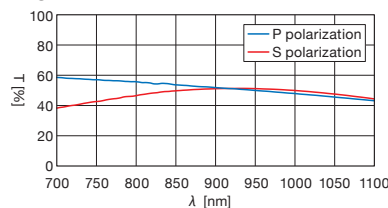
Typical Transmittance Data

T: Transmission

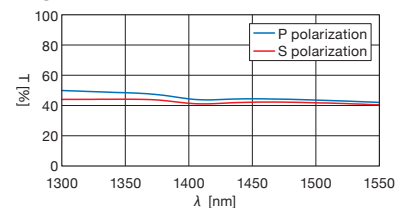
HBCH-550



HBCH-NIR



HBCH-IR

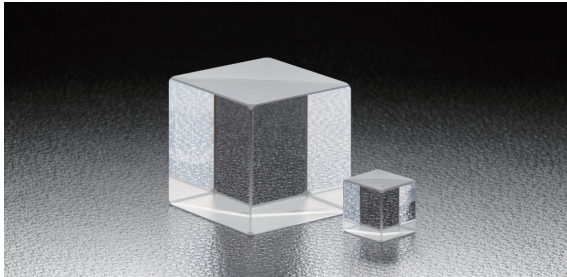


Compatible Optic Mounts

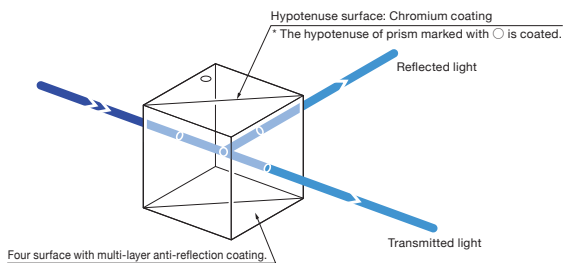
PLH-25, -40 / KKD-25PHRO, -40PHRO

Chromium cube half mirrors consist of two right angle prisms. One of them is coated with chromium (Cr) on the hypotenuse face. Half mirror divides input beam to reflectance and transmittance in 1:1. A beamsplitter of R:T=1:1 is called "Half Mirror".

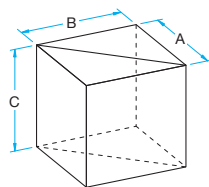
- Four surfaces of the cube are coated with multi-layer anti-reflection coatings
- Approximately one third of the input beam is lost because of absorption of chromium. However these beamsplitters do not depend on wavelength, polarization and incident angle of the input beam, and provide a highly neutral reflectivity.
- For cube beamsplitters, unlike plate beamsplitters, beam deviations at transmission and ghosts rarely occur.



Schematic



Outline Drawing (in mm)



- Tolerance
- A ±0.2
- B ±0.2
- C ±0.1

Specifications

| Part Number | Wavelength Range [nm] | A=B=C [mm] |
|-------------|-----------------------|------------|
| CSCH-10-550 | 400 – 700 | 10 |
| CSCH-15-550 | 400 – 700 | 15 |
| CSCH-20-550 | 400 – 700 | 20 |
| CSCH-25-550 | 400 – 700 | 25 |
| CSCH-30-550 | 400 – 700 | 30 |
| CSCH-40-550 | 400 – 700 | 40 |
| CSCH-50-550 | 400 – 700 | 50 |
| CSCH-10-800 | 750 – 850 | 10 |
| CSCH-15-800 | 750 – 850 | 15 |
| CSCH-20-800 | 750 – 850 | 20 |

Specifications

| | |
|--|--|
| Material | BK7 |
| Surface flatness of substrate | $\lambda/4$ |
| Beam Deviation | <5' |
| Coating | Hypotenuse surface: Chromium Four surfaces: Multi-layer anti-reflection coating |
| Incident angle | 0° |
| Transmittance | Average 28±5% (The average value of the P-Polarization and the S-Polarization) |
| Divergence ratio (reflectance : transmittance) | 1 : 1 |
| Laser Damage Threshold | 0.3J/cm ² (Laser pulse width 10ns, repetition frequency 20Hz) |
| Surface Quality (Scratch-Dig) | 40-20 |
| Clear aperture | 85% of actual aperture |

Guide

- ▶ Please contact our International Sales Division for customized products. (Customized on size, wavelength or R:T, etc.) [Reference](#) B069
- ▶ For a guarantee in reflected wavefront error or transmitted wavefront error, please contact our International Sales Division.

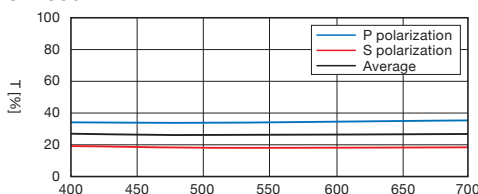
Attention

- ▶ Input beam from the prism side is indicated by a ○.
- ▶ Phase retardation of light input will not be preserved. Use a waveplate for phase compensation.
- ▶ Wavelength dispersion on transmitted and reflected light derives from refraction index and glass thickness. And also, when diverging or introducing a focusing beam, chromatic aberration or spherical aberration may occur.
- ▶ The transmittance curves are based on actual measurements and may be different with manufacturing lots.
- ▶ The surface flatness is the reflected wavefront distortion of the surface before coating.
- ▶ Be sure to wear laser safety goggles when checking optical path and adjusting optical axis.

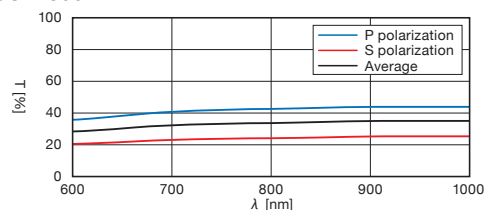
Typical Reflectance Data

T: Transmission

CSCH-550



CSCH-800



Compatible Optic Mounts

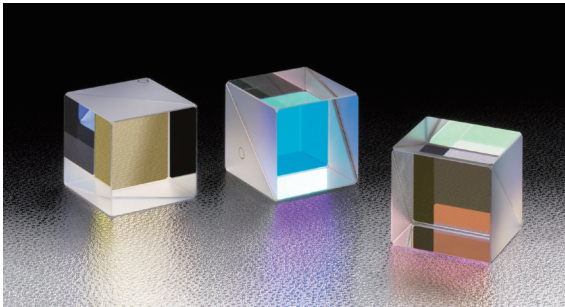
PLH-25, -40 / KKD-25PHRO, -40PHRO

Dielectric Cube Half Mirrors | CSMH

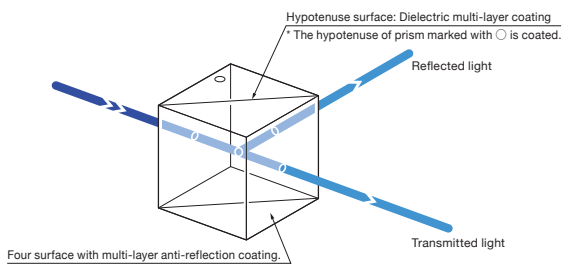
RoHS

Dielectric cube half mirrors consist of two right angle prisms. One of them is coated with dielectric multi-layer partial reflection coating on the hypotenuse face.

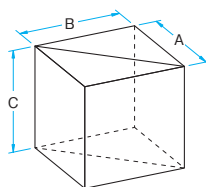
- Half mirror divides input beam to reflectance and transmittance at a 1:1 ratio. A beamsplitter with R:T (1:1 ratio) is called "Half Mirror".
- Four surfaces of the cube are coated with multi-layer anti-reflection coatings.
- The loss of input beam is minimized as there is no absorption from dielectric coating. However the reflection to transmission ratio of these dielectric cube half mirrors vary depending on wavelength, polarization and the incident angle of input beam. These higher refraction half mirrors show strong dependency.



Schematic



Outline Drawing



- Tolerance
 A ± 0.2
 B ± 0.2
 C ± 0.1

(in mm)

Specifications

| | |
|--|--|
| Material | BK7 |
| Surface flatness of substrate | $\lambda/4$ |
| Beam Deviation | $<5'$ |
| Coating | Hypotenuse surface: Dielectric multi-layer coating Four surfaces: Multi-layer anti-reflection coating |
| Incident angle | 0° |
| Divergence ratio (reflectance : transmittance) | 1 : 1 |
| Polarization of the incident beam | Non-polarized beam 45 degrees direction of linearly polarization or circular polarization |
| Laser Damage Threshold | $0.3J/cm^2$ (Laser pulse width 10ns, repetition frequency 20Hz) |
| Surface Quality (Scratch-Dig) | 20-10 |
| Clear aperture | 85% of circle to actual dimension (80% of actual aperture for 5 and 7mm dimension (A=B=C) products.) |

Guide

- Please contact our International Sales Division for customized products. (Customized on size, wavelength or R:T, etc.) [Reference](#) B069
- For a guarantee in reflected wavefront error or transmitted wavefront error, please contact our International Sales Division.

Attention

- Input beam from the prism side is indicated by a \odot . Reflection and refraction over wavelength will differ when light input is applied from the opposite side of the prism.
- The transmittance curves are based on actual measurements and may be different with manufacturing lots.
- The surface flatness is the reflected wavefront distortion of the surface before coating.
- Be sure to wear laser safety goggles when checking optical path and adjusting optical axis.

Specifications

| Part Number | Wavelength Range [nm] | A=B=C [mm] | Transmittance (The average value of the P-Polarization and the S-Polarization) [%] |
|----------------|-----------------------|------------|--|
| CSMH-10-405 | 390 - 410 | 10 | Average 50 ± 3 |
| CSMH-12.7-405 | 390 - 410 | 12.7 | Average 50 ± 3 |
| CSMH-15-405 | 390 - 410 | 15 | Average 50 ± 3 |
| CSMH-20-405 | 390 - 410 | 20 | Average 50 ± 3 |
| CSMH-25-405 | 390 - 410 | 25 | Average 50 ± 3 |
| CSMH-30-405 | 390 - 410 | 30 | Average 50 ± 3 |
| CSMH-05-550 | 400 - 700 | 5 | Average 50 ± 5 |
| CSMH-07-550 | 400 - 700 | 7 | Average 50 ± 5 |
| CSMH-10-550 | 400 - 700 | 10 | Average 50 ± 5 |
| CSMH-12.7-550 | 400 - 700 | 12.7 | Average 50 ± 5 |
| CSMH-15-550 | 400 - 700 | 15 | Average 50 ± 5 |
| CSMH-20-550 | 400 - 700 | 20 | Average 50 ± 5 |
| CSMH-25-550 | 400 - 700 | 25 | Average 50 ± 5 |
| CSMH-30-550 | 400 - 700 | 30 | Average 50 ± 5 |
| CSMH-40-550 | 400 - 700 | 40 | Average 50 ± 5 |
| CSMH-50-550 | 400 - 700 | 50 | Average 50 ± 5 |
| CSMH-10-800 | 750 - 850 | 10 | Average 50 ± 5 |
| CSMH-12.7-800 | 750 - 850 | 12.7 | Average 50 ± 5 |
| CSMH-15-800 | 750 - 850 | 15 | Average 50 ± 5 |
| CSMH-20-800 | 750 - 850 | 20 | Average 50 ± 5 |
| CSMH-25-800 | 750 - 850 | 25 | Average 50 ± 5 |
| CSMH-30-800 | 750 - 850 | 30 | Average 50 ± 5 |
| CSMH-10-1400 | 1300 - 1550 | 10 | Average 50 ± 5 |
| CSMH-12.7-1400 | 1300 - 1550 | 12.7 | Average 50 ± 5 |
| CSMH-20-1400 | 1300 - 1550 | 20 | Average 50 ± 5 |

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Half Mirror Plate

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Beamsplitters

Harmonic Separator

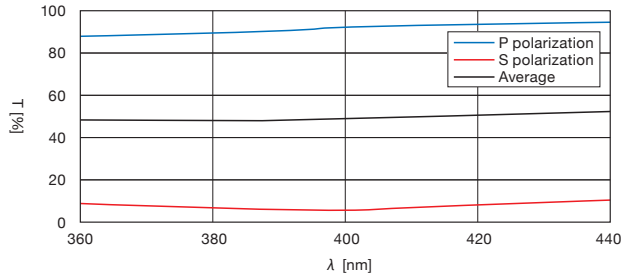
Beam Samplers

Others

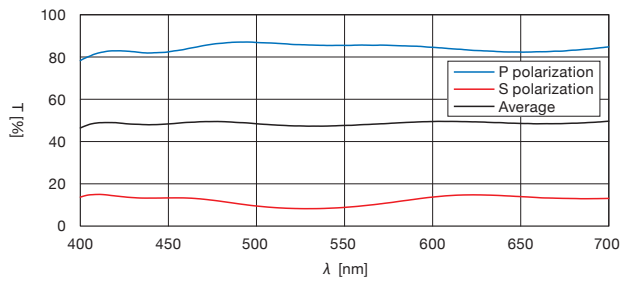
Typical Transmittance Data

T: Transmission

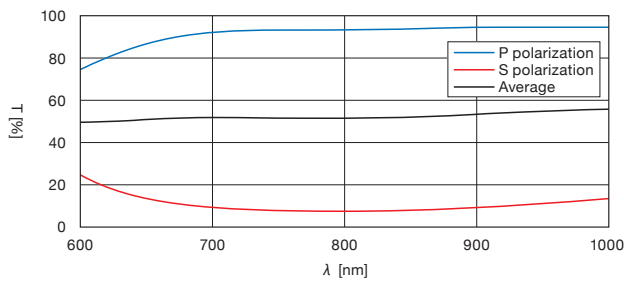
CSMH-405



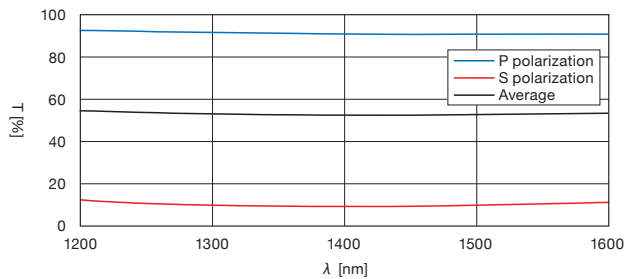
CSMH-550



CSMH-800



CSMH-1400



Compatible Optic Mounts

PLH-25, -40 / KKD-25PHRO, -40PHRO, -60PHRO / SHA-60RO

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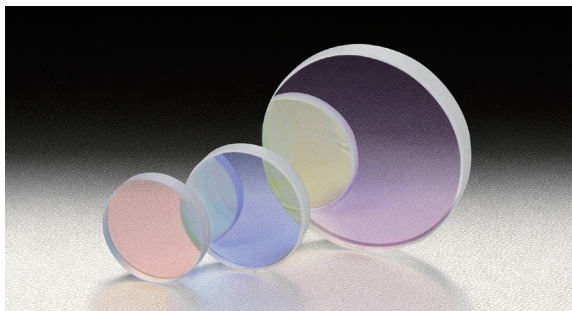
Harmonic Separator

Beam Samplers

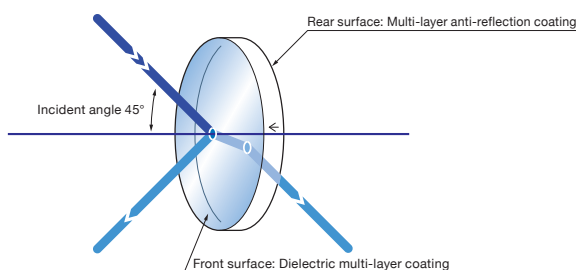
Others

Half-Mirror optics designed for use in Ultraviolet, Visible and Infrared wavelengths. Used for both transmission and divergence of multi-wavelength laser and white light source. Ultra broadband half-mirrors are used for spectrometry applications.

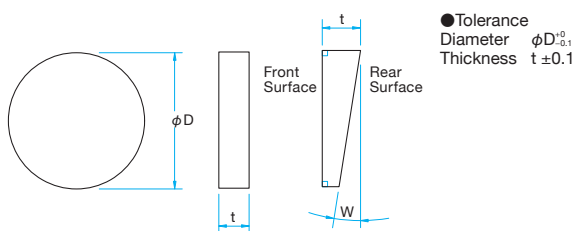
- PMH series have 4 types of ultra-broadband optics with a recovery range from UV to IR.
- PSMH series have 3 types of ultra-broadband optics with a recovery range from Visible to NIR, which are used for optical communication applications.
- Dielectric multi-layer coated optics are an excellent choice for beam deviation applications because of low absorption capabilities.
- Its low polarization characteristic can also be applied in beam deviation with a linear polarization laser or a laser light.
- Sigma Koki produces plate form optics that are light weight and maintain low dispersion with less aberration.
- Both wedge and plate type mirrors are made to have "low ghosting and low interference effect."



Schematic



Outline Drawing



Specifications

| | |
|--|--|
| Material | BK7, Synthetic fused silica |
| Surface Flatness | $\lambda/10$ |
| Coating | Front surface: Dielectric multi-layer coating Rear surface: Multi-layer anti-reflection coating |
| Incident angle | 45° |
| Divergence ratio (reflectance : transmittance) | 1 : 1 |
| Surface Quality (Scratch-Dig) | 10-5 |
| Clear aperture | 90% of actual aperture |

Guide

- ▶ For customization, we can offer different sizes, wavelengths and deviation ratios. [Reference](#) B069. Please contact our International Sales Division.
- ▶ For guaranteed higher reflectance accuracy and higher transmittance optics, please contact us.
- ▶ An arrow mark will be printed on the thick side of the wedge plate to indicate the surface of the mirror.

Attention

- ▶ When applying a laser linear polarized light, the direction of polarization may affect the ratio of reflectance and transmittance. For a rigorous divergence usage of 1:1 ratio, ensure the direction of polarization is set to 45 degrees or use a circular polarizer.
- ▶ When a laser light transmits through the optics, the light path may shift by a few millimetres horizontally due to the refraction and the thickness of the wedge plate.
- ▶ The transmittance wavelength properties may be different if the incident angle is other than 45 degrees.
- ▶ Please check the arrow mark on the side of the wedge plate that indicates the coated surface.
- ▶ The phase difference of incident light cannot be preserved on transmittance and reflectance light. Please use a wave plate to compensate.

Ultra broadband

| Part Number | Wavelength Range [nm] | Diameter ϕD [mm] | Thickness t [mm] | Material | Parallelism W | Transmittance (The average value of the P-Polarization and the S-Polarization) [%] | Laser Damage Threshold* [J/cm ²] |
|---------------------|-----------------------|------------------------|--------------------|------------------------|-----------------|--|--|
| PMH-25.4C03-10-25/7 | 250 - 700 | $\phi 25.4$ | 3 | Synthetic fused silica | <5" | Average 50±10 | 0.5 |
| PMH-30C03-10-25/7 | 250 - 700 | $\phi 30$ | 3 | Synthetic fused silica | <5" | Average 50±10 | 0.5 |
| PMH-50C05-10-25/7 | 250 - 700 | $\phi 50$ | 5 | Synthetic fused silica | <5" | Average 50±10 | 0.5 |
| PMH-25.4C03-10-3/10 | 300 - 1000 | $\phi 25.4$ | 3 | Synthetic fused silica | <5" | Average 50±10 | 0.5 |
| PMH-30C03-10-3/10 | 300 - 1000 | $\phi 30$ | 3 | Synthetic fused silica | <5" | Average 50±10 | 0.5 |
| PMH-50C05-10-3/10 | 300 - 1000 | $\phi 50$ | 5 | Synthetic fused silica | <5" | Average 50±10 | 0.5 |
| PMH-25.4C03-10-6/18 | 600 - 1800 | $\phi 25.4$ | 3 | BK7 | <5" | Average 50±10 | 0.5 |
| PMH-30C03-10-6/18 | 600 - 1800 | $\phi 30$ | 3 | BK7 | <5" | Average 50±10 | 0.5 |
| PMH-50C05-10-6/18 | 600 - 1800 | $\phi 50$ | 5 | BK7 | <5" | Average 50±10 | 0.5 |
| PMH-25.4C03-10-4/20 | 400 - 2000 | $\phi 25.4$ | 3 | BK7 | <5" | Average 50±10 | 0.5 |
| PMH-30C03-10-4/20 | 400 - 2000 | $\phi 30$ | 3 | BK7 | <5" | Average 50±10 | 0.5 |
| PMH-50C05-10-4/20 | 400 - 2000 | $\phi 50$ | 5 | BK7 | <5" | Average 50±10 | 0.5 |

* Laser pulse width 10ns, repetition frequency 20Hz

Compatible Optic Mounts

BHAN-30S, -50S / MHG-HS25-NL, MP30-NL, MP50-NL

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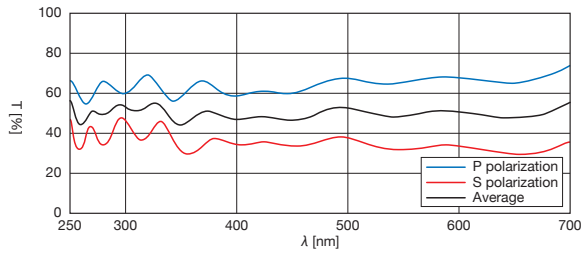
Beam Samplers

Others

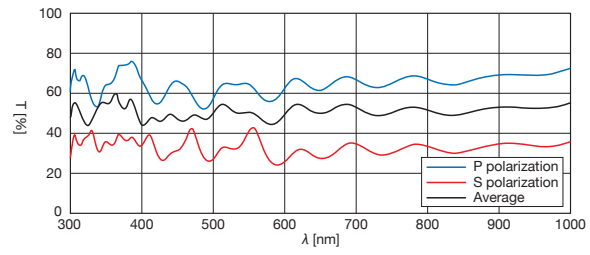
Typical Transmittance Data

T: Transmission

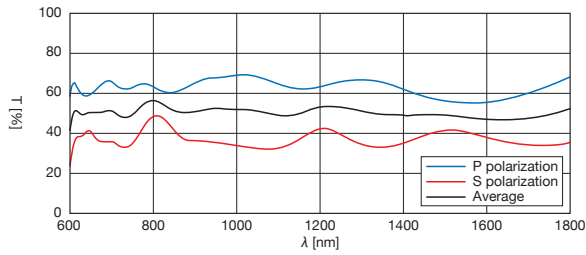
PMH-25/7



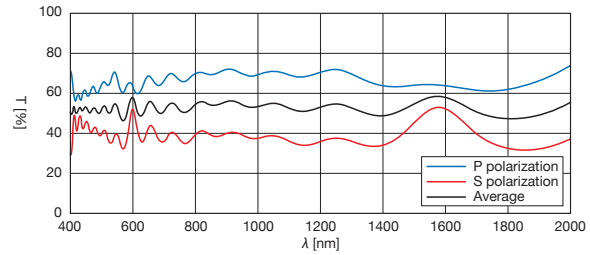
PMH-3/10



PMH-6/18



PMH-4/20



Broadband

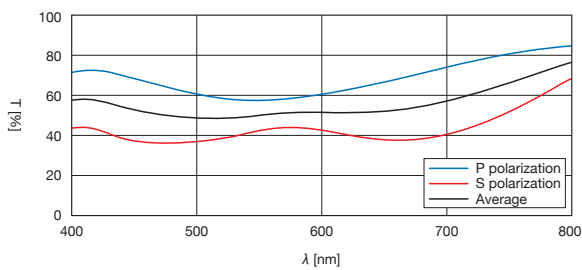
| Part Number | Wavelength Range [nm] | Diameter ϕ D [mm] | Thickness t [mm] | Material | Parallelism W | Transmittance (The average value of the P-Polarization and the S-Polarization) [%] | Laser Damage Threshold* [J/cm ²] |
|---------------------|-----------------------|------------------------|------------------|----------|-----------------------|--|--|
| PSMH-25.4C03-10-550 | 400 – 700 | ϕ 25.4 | 3 | BK7 | <5" | Average 50 \pm 5 | 2.1 |
| PSMH-30C03-10-550 | 400 – 700 | ϕ 30 | 3 | BK7 | <5" | Average 50 \pm 5 | 2.1 |
| PSMH-30C05-10W-550 | 400 – 700 | ϕ 30 | 5 | BK7 | 1 $^{\circ}$ \pm 5' | Average 50 \pm 5 | 2.1 |
| PSMH-40C04-10-550 | 400 – 700 | ϕ 40 | 4 | BK7 | <5" | Average 50 \pm 5 | 2.1 |
| PSMH-50C05-10-550 | 400 – 700 | ϕ 50 | 5 | BK7 | <5" | Average 50 \pm 5 | 2.1 |
| PSMH-50C08-10W-550 | 400 – 700 | ϕ 50 | 8 | BK7 | 1 $^{\circ}$ \pm 5' | Average 50 \pm 5 | 2.1 |
| PSMH-30C03-10-800 | 700 – 900 | ϕ 30 | 3 | BK7 | <5" | 50 \pm 3 (800nm) | 2.1 |
| PSMH-30C05-10W-800 | 700 – 900 | ϕ 30 | 5 | BK7 | 1 $^{\circ}$ \pm 5' | 50 \pm 3 (800nm) | 2.1 |
| PSMH-50C05-10-800 | 700 – 900 | ϕ 50 | 5 | BK7 | <5" | 50 \pm 3 (800nm) | 2.1 |
| PSMH-50C08-10W-800 | 700 – 900 | ϕ 50 | 8 | BK7 | 1 $^{\circ}$ \pm 5' | 50 \pm 3 (800nm) | 2.1 |
| PSMH-30C03-10-1400 | 1300 – 1550 | ϕ 30 | 3 | BK7 | <5" | 50 \pm 3 (1400nm) | 2.1 |
| PSMH-30C05-10W-1400 | 1300 – 1550 | ϕ 30 | 5 | BK7 | 1 $^{\circ}$ \pm 5' | 50 \pm 3 (1400nm) | 2.1 |

* Laser pulse width 10ns, repetition frequency 20Hz

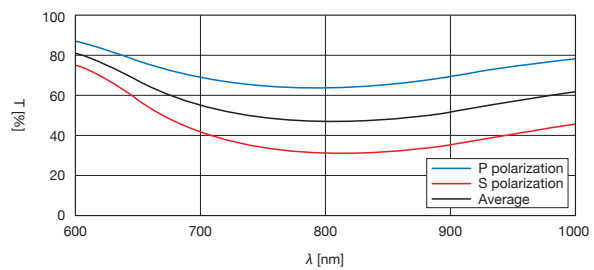
Typical Transmittance Data

T: Transmission

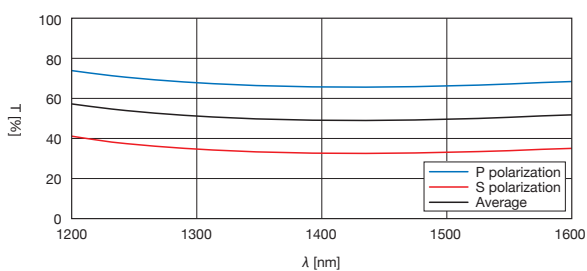
PSMH-550



PSMH-800



PSMH-1400



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Thin Plate Beamsplitter | **MPSMH**

RoHS

Catalog Code

W3017

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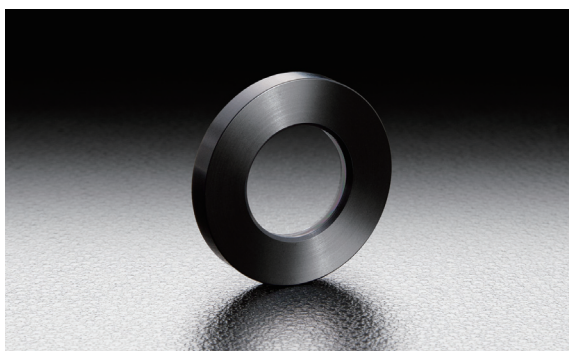
Harmonic Separator

Beam Samplers

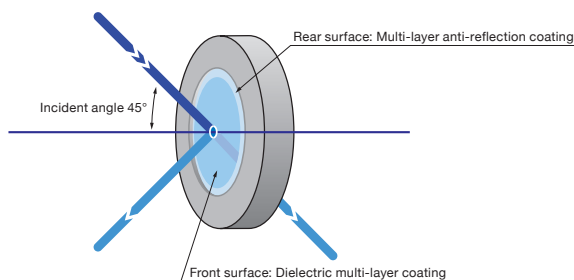
Others

Extremely thin beamsplitter.
It can be inserted into an optical light path without any beam shift or chromatic dispersion for any light transmittance application.

- 2 choices of thickness, 300um and 90um.
- Dielectric multi-layer optical coating with reflectance and transmittance ratios at 1:1
- Dielectric multi-layer optical coating on the surface and AR coating on the rear to provide a mirror with no loss of power.
- The plate is firmly held by a glass retainer to avoid thermal expansion.
- Because of our fabrication method, it offers good durability and high resistance against vibration and with our traditional and proven optical polishing process on silica quartz which is different from a pellicle.

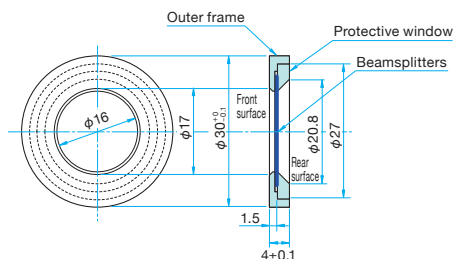


Schematic



Outline Drawing

(in mm)



Specifications

| Part Number | Wavelength Range [nm] | Optics Thickness [mm] | Surface Accuracy after coating |
|---------------------|-----------------------|-----------------------|--|
| MPSMH-30C0.3-1-550 | 400 - 700 | 0.3±0.03 | Reflectance: λ Transmittance: λ |
| MPSMH-30C0.09-1-550 | 400 - 700 | 0.09±0.01 | Reflectance: Polishing Transmittance: Polishing |

Specifications

| | |
|--|---|
| Material | Synthetic fused silica |
| Coating | Front surface: Dielectric multi-layer coating Rear surface (45 degrees taper hole): Multi-layer anti-reflection coating |
| Incident angle | 45° |
| Transmittance | Average 50±5% (The average value of the P-Polarization and the S-Polarization) |
| Divergence ratio (reflectance : transmittance) | 1 : 1 |
| Surface Quality (Scratch-Dig) | 40-20 |
| Clear aperture | φ10mm |
| Material properties | Protective window: Synthetic fused silica Outer frame: Aluminum Finishing: Matt black almite |

Guide

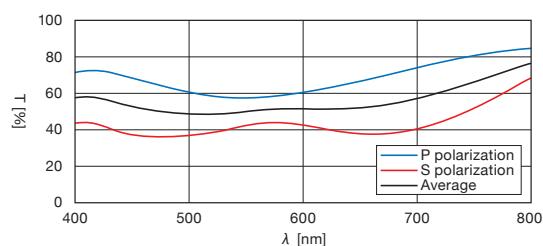
- ▶ For customization, we can offer different sizes, wavelengths and deviation ratios. [Reference](#) B069
Please contact our International Sales Division.

Attention

- ▶ Thin beamsplitters are extremely thin and fragile. Special care must be taken during cleaning and handling.
- ▶ When removing dust from the surface, do not use optics tissue paper to clean. Use a compress gas spray instead.
- ▶ When applying a laser linear polarized light, the direction of polarization may affect the ratio of reflectance and transmittance. For a rigorous divergence usage of 1:1 ratio, ensure the direction of polarization is set to 45 degrees or use a circular polarizer.
- ▶ The transmittance wavelength properties may be different if the incident angle is other than 45 degrees.
- ▶ Avoid pushing the glass retainer as the mirror can bend or break. When handling, please use the other metal frame.
- ▶ The surface reflectance accuracy may deteriorate when used outside recommended operating temperature.
- ▶ The phase difference of incident light cannot be preserved on transmittance and reflectance light. Please use a wave plate to compensate.

Typical Transmittance Data

T: Transmission

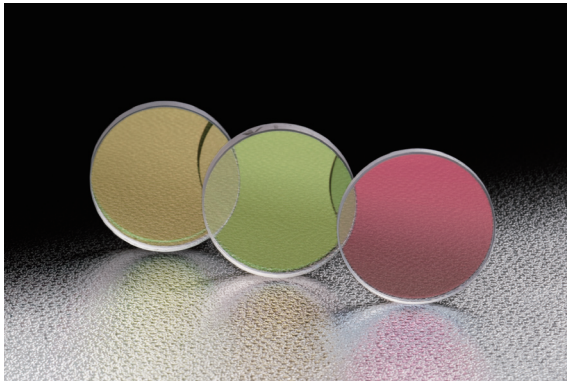


Compatible Optic Mounts

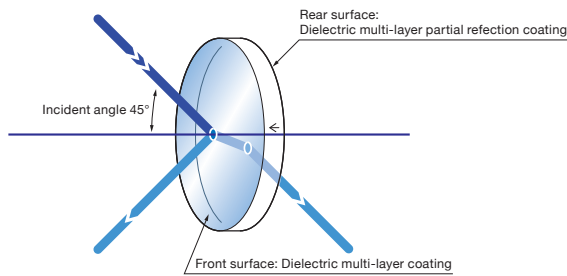
MHG-HS30-NL / BHAN-30S

Laser line plate mirrors are part of plate beamsplitters that are optically coated with dielectric multi-layer on the front surface of optical parallels or wedged substrates. The rear surface is coated with multi-layer anti-reflection.

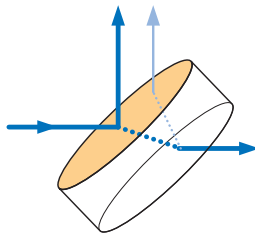
- Half mirror divides input beam to reflectance and transmittance in 1:1. A beamsplitter of R:T=1:1 is called "Half Mirror".
- Any loss from the input beams on this product is minimized because dielectric coating has no absorption properties. However, the input ratio of reflection to transmission depends on wavelength, polarization and incident angle of input beam.
- Plate beamsplitters have beam deviations on transmission and ghost on rear surface reflections. Wedged substrates are used to prevent ghost.



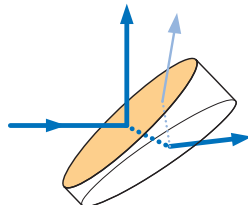
Schematic



Optical Parallel



Wedged Substrate



Specifications

| | |
|--|---|
| Material | BK7, Synthetic fused silica, CaF ₂ |
| Surface Flatness | $\lambda/10$ (PSMH-157 is Polished) |
| Coating | Front surface: Dielectric multi-layer partial reflection coating Rear surface: Multi-layer anti-reflection coating |
| Incident angle | 45° |
| Divergence ratio (reflectance : transmittance) | 1 : 1 |
| Surface Quality (Scratch-Dig) | 10-5 (PSMH-157: 40-20) |
| Clear aperture | 90% of actual aperture |

Guide

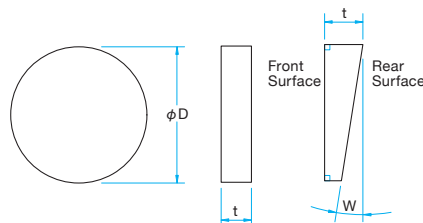
- ▶ Please contact our International Sales Division for customized products. (Customized on size, wavelength or R:T, etc.) **Reference** B069
- ▶ We also have ultra-wideband, broadband and cube types.
- ▶ For a guarantee in reflected wavefront error or transmitted wavefront error, please contact our International Sales Division.
- ▶ On most thickness surfaces, there is a thickness direction arrow marked for wedged types.

Attention

- ▶ Should these products do not function as a half mirror, please check the polarization characteristics of the light source. Do note that LD laser is linear in polarization.
- ▶ The beam deviation at transmission of a wedged beamsplitter is large compared to a one made of optical parallel.
- ▶ The amount of beam deviation of a beamsplitter depends on the thickness of the substrate and the wavelength or the incident angle of the input beam.
- ▶ Transmission curves are based on actual measurements and may be different with manufacturing lots.
- ▶ Surface flatness is the reflected wavefront distortion of the surface prior to coating.

Outline Drawing

(in mm)



- Tolerance Diameter $\phi D_{\pm 0.1}$
- Thickness $t \pm 0.1$

Compatible Optic Mounts

BHAN-30S, -50S / MHG-MP30-NL, MP50-NL

| Laser Line | | | | | | | |
|------------------------|-----------------------|------------------------|------------------|------------------------|---------------|--|--|
| Part Number | Wavelength Range [nm] | Diameter ϕ D [mm] | Thickness t [mm] | Material | Parallelism W | Reflectance:R Transmittance:T (The average value of the P-Polarization and the S-Polarization) [%] | Laser Damage Threshold* [J/cm ²] |
| PSMH-30C03-P-157 | 157 | ϕ 30 | 3 | CaF ₂ | <3' | R=40±10 | 0.5 |
| PSMH-50C05-P-157 | 157 | ϕ 50 | 5 | CaF ₂ | <3' | R=40±10 | 0.5 |
| PSMH-30C03-10-193 | 193 | ϕ 30 | 3 | Synthetic fused silica | <5" | T=45±5 | 1 |
| PSMH-30C05-10W-193 | 193 | ϕ 30 | 5 | Synthetic fused silica | 1°±5' | T=45±5 | 1 |
| PSMH-50C05-10-193 | 193 | ϕ 50 | 5 | Synthetic fused silica | <5" | T=45±5 | 1 |
| PSMH-50C08-10W-193 | 193 | ϕ 50 | 8 | Synthetic fused silica | 1°±5' | T=45±5 | 1 |
| PSMH-30C03-10-248/266 | 248 – 266 | ϕ 30 | 3 | Synthetic fused silica | <5" | T=50±3 | 2 |
| PSMH-30C05-10W-248/266 | 248 – 266 | ϕ 30 | 5 | Synthetic fused silica | 1°±5' | T=50±3 | 2 |
| PSMH-50C05-10-248/266 | 248 – 266 | ϕ 50 | 5 | Synthetic fused silica | <5" | T=50±3 | 2 |
| PSMH-50C08-10W-248/266 | 248 – 266 | ϕ 50 | 8 | Synthetic fused silica | 1°±5' | T=50±3 | 2 |
| PSMH-30C03-10-308/355 | 308 – 355 | ϕ 30 | 3 | Synthetic fused silica | <5" | T= Average 50±5 | 2 |
| PSMH-30C05-10W-308/355 | 308 – 355 | ϕ 30 | 5 | Synthetic fused silica | 1°±5' | T= Average 50±5 | 2 |
| PSMH-50C05-10-308/355 | 308 – 355 | ϕ 50 | 5 | Synthetic fused silica | <5" | T= Average 50±5 | 2 |
| PSMH-50C08-10W-308/355 | 308 – 355 | ϕ 50 | 8 | Synthetic fused silica | 1°±5' | T= Average 50±5 | 2 |
| PSMH-30C03-10-405 | 390 – 410 | ϕ 30 | 3 | BK7 | <5" | T=50±3 | 2.1 |
| PSMH-30C05-10W-405 | 390 – 410 | ϕ 30 | 5 | BK7 | 1°±5' | T=50±3 | 2.1 |
| PSMH-50C05-10-405 | 390 – 410 | ϕ 50 | 5 | BK7 | <5" | T=50±3 | 2.1 |
| PSMH-50C08-10W-405 | 390 – 410 | ϕ 50 | 8 | BK7 | 1°±5' | T=50±3 | 2.1 |
| PSMH-30C03-10-1064 | 1064 | ϕ 30 | 3 | BK7 | <5" | T=50±3 | 20 |
| PSMH-30C05-10W-1064 | 1064 | ϕ 30 | 5 | BK7 | 1°±5' | T=50±3 | 20 |
| PSMH-50C05-10-1064 | 1064 | ϕ 50 | 5 | BK7 | <5" | T=50±3 | 20 |
| PSMH-50C08-10W-1064 | 1064 | ϕ 50 | 8 | BK7 | 1°±5' | T=50±3 | 20 |

*Laser pulse width 10ns (PSMH-157: 20ns), repetition frequency 20Hz

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Beamsplitters

Harmonic Separator

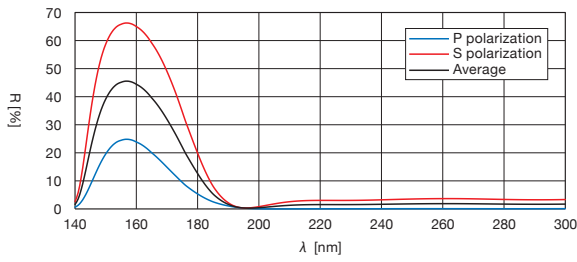
Beam Samplers

Others

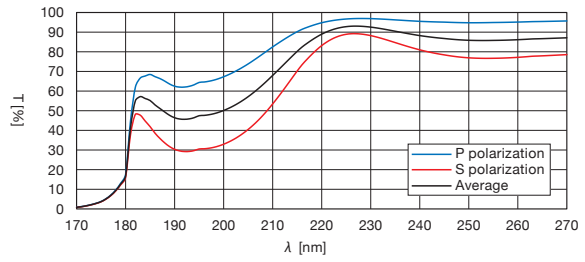
Typical Reflectance Data & Typical Transmittance Data

R: Reflectance T: Transmission

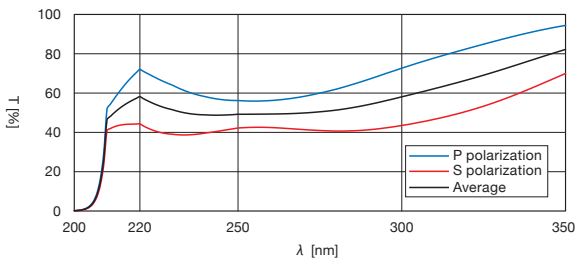
PSMH-157



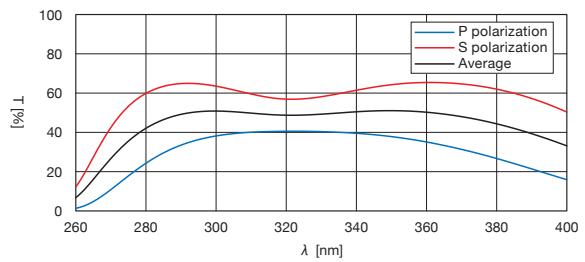
PSMH-193



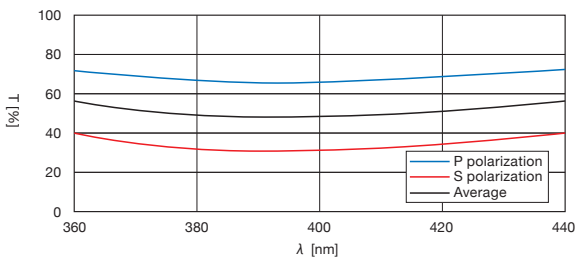
PSMH-248/266



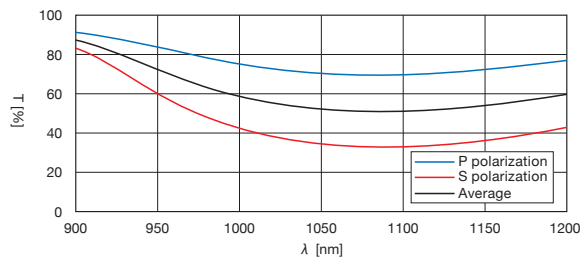
PSMH-308/355



PSMH-405



PSMH-1064



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Beamsplitters

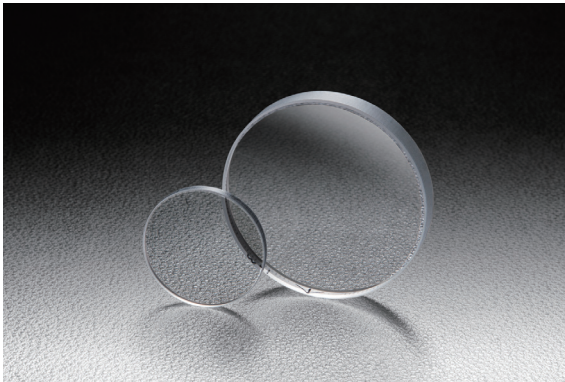
Harmonic Separator

Beam Samplers

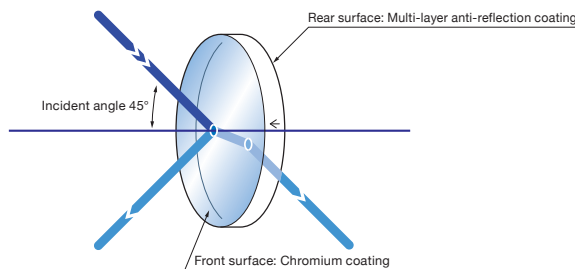
Others

Chromium plate half mirrors are part of plate beamsplitters that are coated with chromium (Cr) on the front surface of optical parallels or wedged substrates. The rear surface is coated with multi-layer anti-reflection.

- Half mirror divides input beam to reflectance and transmittance in 1:1. A beamsplitter of R:T=1:1 is called "Half Mirror".
- Approximately one third of the input beam is lost because of absorption of chromium. However these beamsplitters do not depend on wavelength, polarization and incident angle of the input beam, and provide a highly neutral reflectivity.
- Plate beamsplitters have beam deviations on transmission and ghost on rear surface reflections. Wedged substrates are used to prevent ghost.

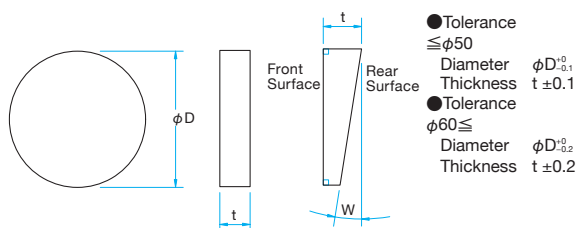


Schematic



Outline Drawing

(in mm)



Specifications

| | |
|--|---|
| Material | BK7 |
| Surface Flatness | $\lambda/10$ |
| Coating | Front surface: Chromium Rear surface: Multi-layer anti-reflection coating |
| Incident angle | 45° |
| Transmittance | Average 30±5% (The average value of the P-Polarization and the S-Polarization) |
| Divergence ratio (reflectance : transmittance) | 1 : 1 |
| Laser Damage Threshold | 0.25J/cm ² (Laser pulse width 10ns, repetition frequency 20Hz) |
| Surface Quality (Scratch-Dig) | 40-20 |
| Clear aperture | 90% of actual aperture |

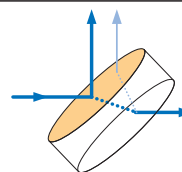
Guide

- ▶ Please contact our International Sales Division for customized products. (Customized on size, wavelength or R:T, etc.) [Reference](#) B069
- ▶ For a guarantee in reflected wavefront error or transmitted wavefront error, please contact our International Sales Division.

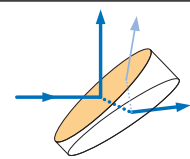
Attention

- ▶ The beam deviation at transmission of a wedged beamsplitter is large compared to a one made of optical parallel.
- ▶ The amount of beam deviation of a beamsplitter depends on the thickness of the substrate and the wavelength or the incident angle of the input beam.
- ▶ Transmission curves are based on actual measurements and may be different with manufacturing lots.
- ▶ Surface flatness is the reflected wavefront distortion of the surface prior to coating.
- ▶ Be sure to wear laser safety goggles when checking optical path and adjusting optical axis.

Optical Parallel



Wedged Substrate



Specifications

| Part Number | Wavelength Range [nm] | Diameter ϕD [mm] | Thickness t [mm] | Parallelism W |
|---------------------|-----------------------|------------------------|--------------------|-----------------|
| PSCH-25.4C03-10-550 | 400 - 700 | $\phi 25.4$ | 3 | $< 5''$ |
| PSCH-30C03-10-550 | 400 - 700 | $\phi 30$ | 3 | $< 5''$ |
| PSCH-30C05-10W-550 | 400 - 700 | $\phi 30$ | 5 | $1'' \pm 5''$ |
| PSCH-40C04-10-550 | 400 - 700 | $\phi 40$ | 4 | $< 5''$ |
| PSCH-50C05-10-550 | 400 - 700 | $\phi 50$ | 5 | $< 5''$ |
| PSCH-50C08-10W-550 | 400 - 700 | $\phi 50$ | 8 | $1'' \pm 5''$ |
| PSCH-60C06-10-550 | 400 - 700 | $\phi 60$ | 6 | $< 5''$ |
| PSCH-100C10-10-550 | 400 - 700 | $\phi 100$ | 10 | $< 5''$ |
| PSCH-100C15-10W-550 | 400 - 700 | $\phi 100$ | 15 | $1'' \pm 5''$ |
| PSCH-25.4C03-10-800 | 750 - 850 | $\phi 25.4$ | 3 | $< 5''$ |
| PSCH-30C03-10-800 | 750 - 850 | $\phi 30$ | 3 | $< 5''$ |
| PSCH-30C05-10W-800 | 750 - 850 | $\phi 30$ | 5 | $1'' \pm 5''$ |
| PSCH-50C05-10-800 | 750 - 850 | $\phi 50$ | 5 | $< 5''$ |
| PSCH-50C08-10W-800 | 750 - 850 | $\phi 50$ | 8 | $1'' \pm 5''$ |

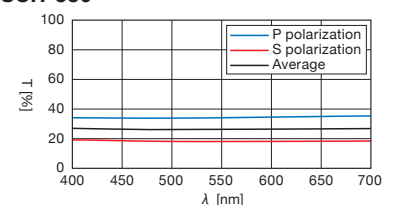
Compatible Optic Mounts

BHAN-30S, -50S / MHAN-25.4S, -40S, -60S / MHG-MP25-NL, MP30-NL, MP50-NL

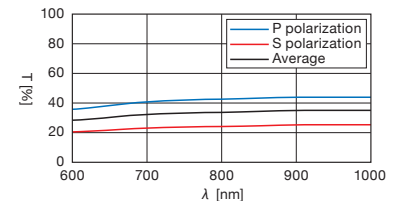
Typical Transmittance Data

PSCH-550

T: Transmission



PSCH-800



About light behaviour on a beamsplitter

A half mirror is designed with reflectance and transmission of light with a 1:1 ratio. If light incident direction and polarization conditions change, it may impact the ratio.

Reflectance and transmittance properties of the incident light direction

Chrome coating and multi-wavelength coating application.

Reflection properties change when light is projected onto the coated and black surfaces. Any configuration similar to Michelson interferometer may require both sides to have incident light. In this case, light ratios may be unbalanced.

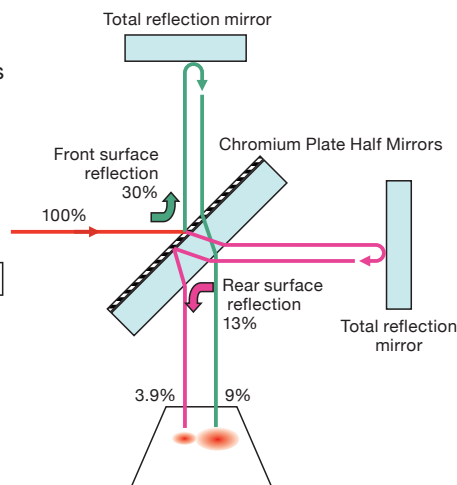
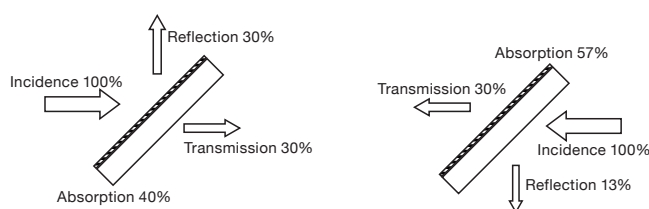
Choose the following set up if the light incident direction can be selected.

Incident light onto the coated surface of plate type beamsplitter.

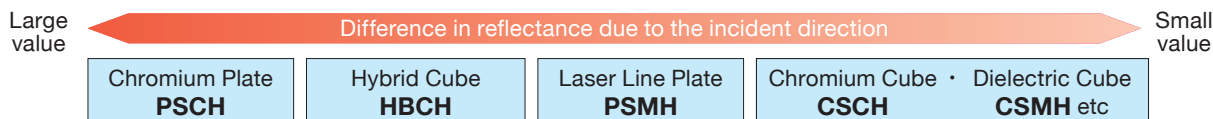
Incident light onto the \odot mark surface for cube type beamsplitter.

If the Incident light is on the wrong surface, the specifications mentioned in the catalogue cannot be realized.

Comparison reflectance and transmittance properties of the incident light direction in the chromium plate half mirror.



The difference in reflectance due to the incident direction occurs when there is absorption in the coating. It does not occur in the dielectric multilayer coating.



The reflectance and the transmittance of a polarized light incident

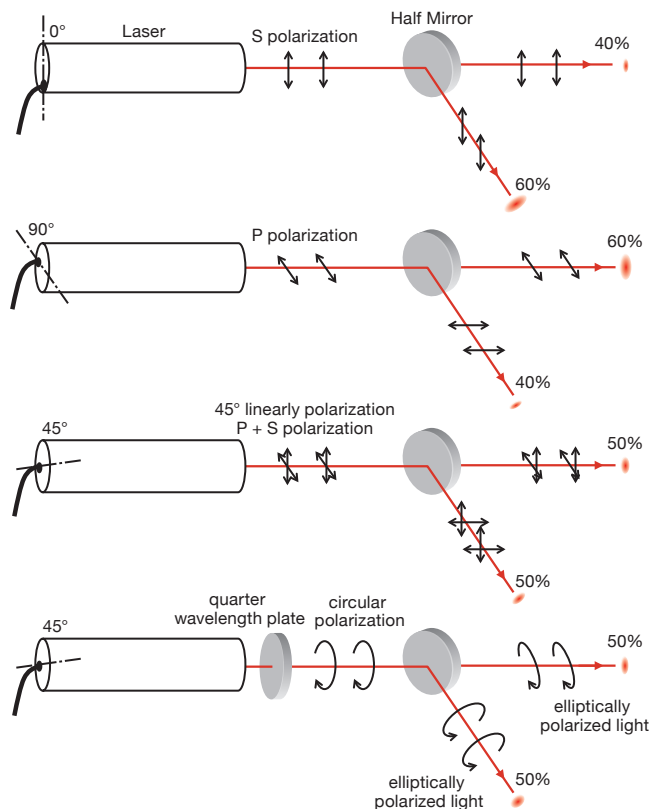
In case fo using Laser

Light emitted from the laser is linearly polarized light. Because of this, even though it is used in the experiments and the optical system which are not related to the polarization, it is necessary to take into account the polarization characteristics of the beam splitter.

The transmittance and the reflectance may change in accordance with the type of beamsplitter and its polarization direction.

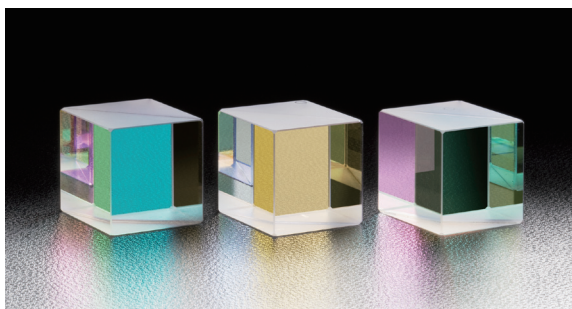
To split the light into a balanced light ratio, a non-polarized beam splitter (NPCH) is recommended.

The polarization properties of the laser has no influence to it.

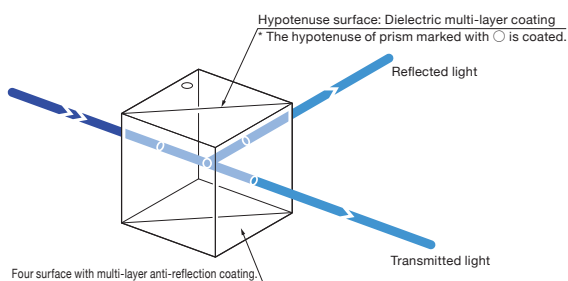


Cube beamsplitters with dielectric multi-layer coated to the oblique faces of a 45° right angle prism. Divides beams at reflected light (R) : transmission light (T) ratio of 1:2 or 1:3.

- Anti-reflection coating (AR coat) is applied to the incident and outgoing planes.
- The dielectric multi-layer coating has virtually zero light absorption and very low light intensity loss. However, transmittance and reflectance may change according to wavelength, polarization and incident angles. A higher reflectance will occur from a higher dependence.
- In contrast to plate type half mirrors, cube mirrors have no ghosting or transmission optical path deviation.

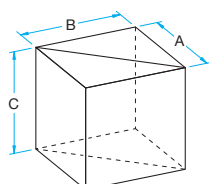


Schematic



Outline Drawing

(in mm)



- Tolerance
- A ± 0.2
- B ± 0.2
- C ± 0.1

Specifications

| | |
|-----------------------------------|--|
| Material | BK7 |
| Surface Flatness | $\lambda/4$ |
| Wavelength Range | 400 – 700nm |
| Beam Deviation | <5' |
| Coating | Hypotenuse surface: Dielectric multi-layer coating Four surfaces: Multi-layer anti-reflection coating |
| Incident angle | 0° |
| Polarization of the incident beam | Non-polarized beam 45 degrees direction of linearly polarization or circular polarization |
| Laser Damage Threshold | 0.3J/cm ² (Laser pulse width 10ns, repetition frequency 20Hz) |
| Surface Quality (Scratch-Dig) | 20-10 |
| Clear aperture | 85% of actual aperture |

Guide

- ▶ Please contact our International Sales Division for customized products. (Customized on size, wavelength or R:T, etc.) [Reference](#) B069
- ▶ For a guarantee in reflected wavefront error or transmitted wavefront error, please contact our International Sales Division.

Attention

- ▶ Introduce light (from or to) the prism on the side indicated by ○ (half coated side).
- ▶ The transmission curve on the graph is based on actual measurements and may vary from different production lots.
- ▶ Phase retardation of inputting light will not be preserved. Use waveplate for phase compensation.
- ▶ Use only non-polarized light or circular polarized light as incident light for dielectric multi-layer coated beam splitters. Using polarized light may result in division ratios that vary according to polarization components.

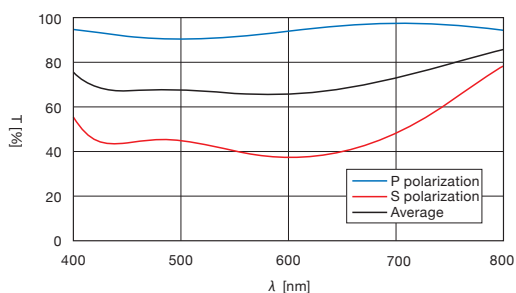
Specifications

| Part Number | Reflectance : Transmittance | A=B=C [mm] | Transmittance at 550nm | Transmittance at 400-700nm |
|--------------|-----------------------------|------------|--|--|
| | | | (The average value of the P-Polarization and the S-Polarization) [%] | (The average value of the P-Polarization and the S-Polarization) [%] |
| CSM33-10-550 | 1 : 2 | 10 | 67 \pm 5 | <80 |
| CSM33-20-550 | 1 : 2 | 20 | 67 \pm 5 | <80 |
| CSM25-10-550 | 1 : 3 | 10 | 75 \pm 5 | <90 |
| CSM25-20-550 | 1 : 3 | 20 | 75 \pm 5 | <90 |

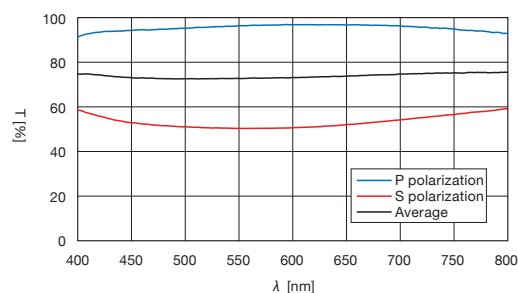
Typical Transmittance Data

T: Transmission

CSM33



CSM25

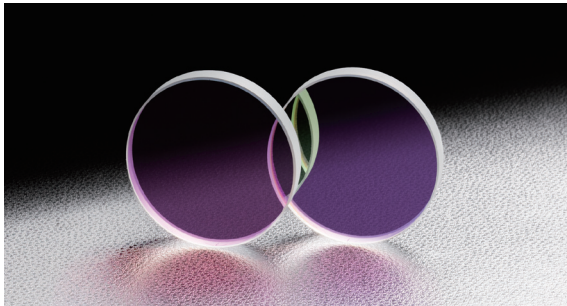


Compatible Optic Mounts

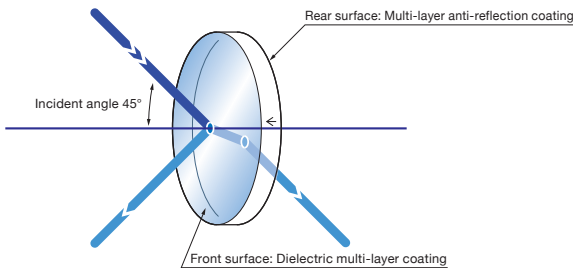
PLH-25, -40 / KKD-25PHRO, -40PHRO

Plate-type beam splitters with a dielectric multi-layer coat on a parallel plate and a wedge substrate. Divides beams at a reflected light (R) : transmission light (T) ratio of 1:2 or 1:3. The rear surface is coated with anti-reflection (AR).

- The dielectric multi-layer coating has virtually zero light absorption and very low light intensity loss. However, transmittance and reflectance may change according to wavelength, polarization and incident angles. A higher reflectance will occur from a higher dependence. Some deviation of the transmission optical path or ghosting may occur. To prevent ghosting, use wedge substrate type of beam splitters.

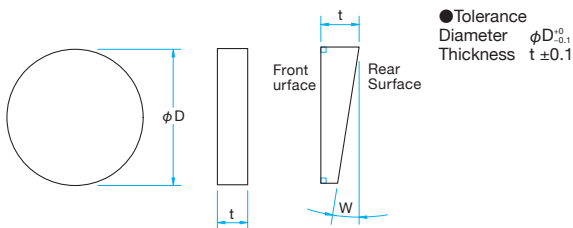


Schematic



Outline Drawing

(in mm)



Specifications

| | |
|-------------------------------|--|
| Material | BK7 |
| Surface Flatness | $\lambda/10$ |
| Coating | Front surface: Dielectric multi-layer coating Rear surface: Multi-layer anti-reflection coating |
| Wavelength Range | 400 – 700nm |
| Incident angle | 45° |
| Laser Damage Threshold | 2.1J/cm ² (Laser pulse width 10ns, repetition frequency 20Hz) |
| Surface Quality (Scratch-Dig) | 10-5 |
| Clear aperture | 90% of actual aperture |

Guide

- Please contact our International Sales Division for customized products. (Customized on size, wavelength or R:T, etc.) **Reference** B069
- For a guarantee in reflected wavefront error or transmitted wavefront error, please contact our International Sales Division.
- Wedge type substrates have a thickness direction arrow that is marked on most surfaces.

Attention

- The transmission curve on the graph is based on actual measurements and may vary from different production lots.
- Surface flatness is the reflected wavefront distortion of the surface prior to coating.
- Compared to precision parallel plate type splitters, wedged substrate type beam splitters can prevent ghosting caused by rear surface reflection and significantly increase the displacement of the optical path.
- Dielectric multi-layer coated beam splitters sometimes do not function effectively in specified division ratios. During such case, first check the polarization characteristics of the light source (laser). Do keep in mind that lasers used for the semiconductor field emit a linear polarized light.

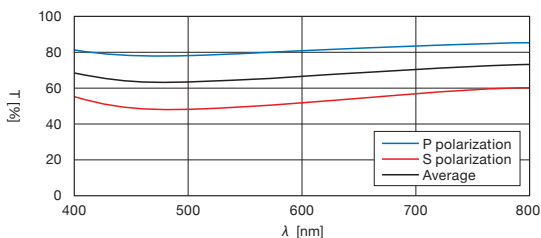
Specifications

| Part Number | Reflectance : Transmittance | Diameter ϕD [mm] | Thickness t [mm] | Parallelism W | Transmittance at 550nm (The average value of the P-Polarization and the S-Polarization) | | Transmittance at 400-700nm (The average value of the P-Polarization and the S-Polarization) | |
|----------------------|-----------------------------|------------------------|--------------------|------------------|--|-----|--|-----|
| | | | | | [%] | [%] | [%] | [%] |
| PSM33-25.4C03-10-550 | 1 : 2 | $\phi 25.4$ | 3 | $<5''$ | 67±3 | <80 | | |
| PSM33-30C03-10-550 | 1 : 2 | $\phi 30$ | 3 | $<5''$ | 67±3 | <80 | | |
| PSM33-30C05-10W-550 | 1 : 2 | $\phi 30$ | 5 | $1^\circ \pm 5'$ | 67±3 | <80 | | |
| PSM25-25.4C05-10-550 | 1 : 3 | $\phi 25.4$ | 3 | $<5''$ | 75±3 | <90 | | |
| PSM25-30C03-10-550 | 1 : 3 | $\phi 30$ | 3 | $<5''$ | 75±3 | <90 | | |
| PSM25-30C05-10W-550 | 1 : 3 | $\phi 30$ | 5 | $1^\circ \pm 5'$ | 75±3 | <90 | | |

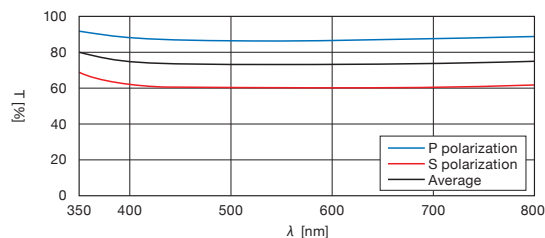
Typical Transmittance Data

T: Transmission

PSM33



PSM25



Compatible Optic Mounts

BHAN-30S / MHAN-25.4DS / MHG-MP25-NL, MP30-NL

Variable Beamsplitter Light path corrector

VBS
WSQNA/WBNA

RoHS
RoHS

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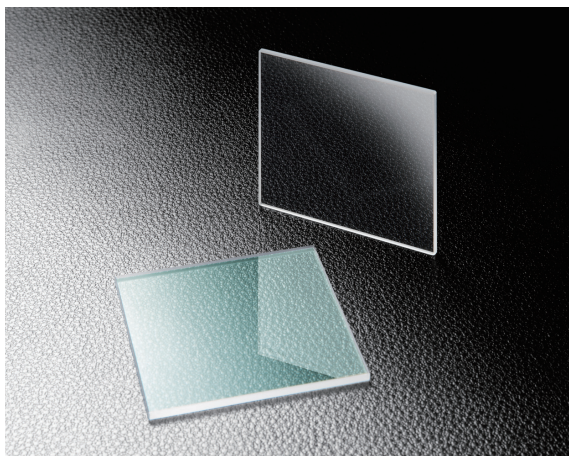
Harmonic Separator

Beam Samplers

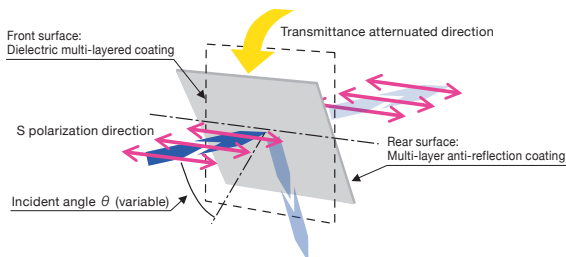
Others

With a variable beam splitter, the incident angle of a laser can be changed. The (R:T) ratios can also be modified. This is commonly used for when adjusting the light quantity for the laser without a variable adjustment of the light quantity or the laser to be stabilized, when weakening the light quantity temporarily by adjusting the optical system, and when splitting to any two light quantity.

- Since it is used a dielectric multilayer coating, it is excellent in durability and light resistance.
- The beam shift caused by the tilt of the beam splitter can be removed by using with a correcting plate. (See how to use)
- It can be used for arbitrary polarization. However, the transmittance characteristic depends on the polarization state.

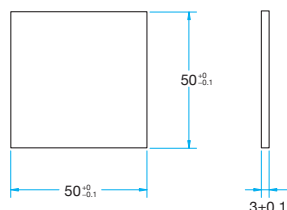


Schematic



Outline Drawing

(in mm)



Variable beamsplitter

| Part Number | Wavelength Range [nm] | Transmittance of S polarization ($\theta=0^\circ$) [%] | Transmittance of S polarization ($\theta=45^\circ$) [%] | Material | Laser Damage Threshold* [J/cm ²] |
|------------------|-----------------------|--|---|------------------------|--|
| VBS-50S03-1-266 | 266 | >90 | <5 | Synthetic fused silica | 1 |
| VBS-50S03-1-355 | 355 | >93 | <5 | Synthetic fused silica | 1 |
| VBS-50S03-1-532 | 532 | >95 | <5 | BK7 | 2.5 |
| VBS-50S03-1-1064 | 1064 | >95 | <5 | BK7 | 3.5 |

* Laser pulse width 10ns, repetition frequency 20Hz

Light path corrector

| Part Number | Wavelength Range [nm] | Transmittance of S polarization ($\theta=0^\circ - 45^\circ$) [%] | Material | Laser Damage Threshold* [J/cm ²] |
|-------------------------|-----------------------|---|------------------------|--|
| WSQNA-50S03-1-266-0/45D | 266 | Average 97 | Synthetic fused silica | 1 |
| WSQNA-50S03-1-355-0/45D | 355 | Average 97 | Synthetic fused silica | 1 |
| WBNA-50S03-1-532-0/45D | 532 | Average 98 | BK7 | 2.5 |
| WBNA-50S03-1-1064-0/45D | 1064 | Average 98 | BK7 | 3.5 |

* Laser pulse width 10ns, repetition frequency 20Hz

Specifications

| | |
|----------------------------------|---|
| Material | BK7, Synthetic fused silica |
| Surface Flatness | λ |
| Parallelism | <5" |
| Coating | VBS Front surface: Dielectric multi-layer Coating Rear surface: Multi-layer anti-reflection coating WBMA, WSQMA Both surfaces: Multi-layer anti-reflection coating |
| Surface Quality (Scratch-Dig) | 10-5 |
| Clear aperture | Circle that internally connected to 90% of the side length |
| Effective beam incident diameter | Ellipsoidal 30×43mm (Angle of inclination) |

Guide

▶ Different size, wavelength and deviation ratio are not mentioned in this catalog but available as custom product upon request.

Reference B069

▶ We offer the most comprehensive range of beam splitter holder and stages to choose from. Let us know the angle of your choice.

▶ This variable attenuator (model SHPS) can be used as a system and is available from this catalogue page.



Attention

▶ When using with high power laser, make sure to execute at the end edge of the reflected light.

▶ The reflectance properties of the optics may change in a high temperature environment.

▶ When adjusting the transmittance, the incident angle may change and cause the light path to shift. To correct this, please use the light path corrector (model WSQNA/WBNA)

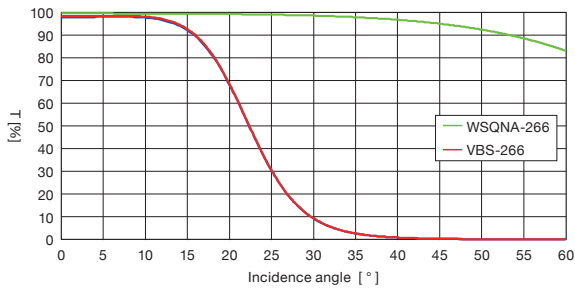
▶ For a large beam size at dia 30mm or more and used it at a high inclination level, the beam can be cut at the reflected area.

▶ For "P" polarization use, make sure that the incident angle is at 45 degrees or more.

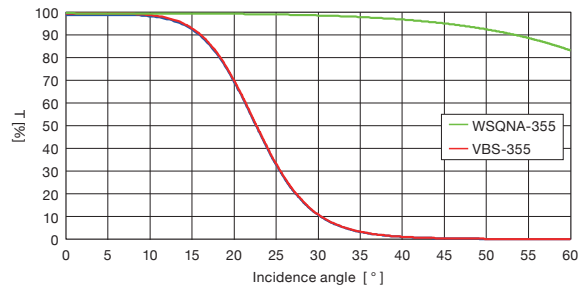
Typical Transmittance Data

T: Transmission (S polarization)

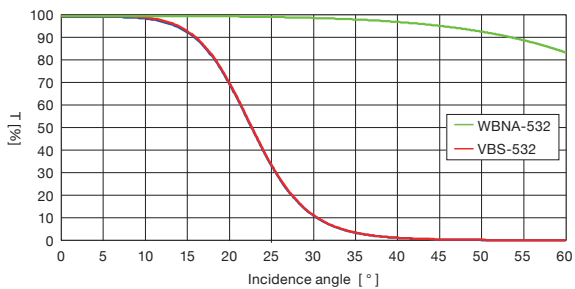
VBS-266 / WSQNA-266



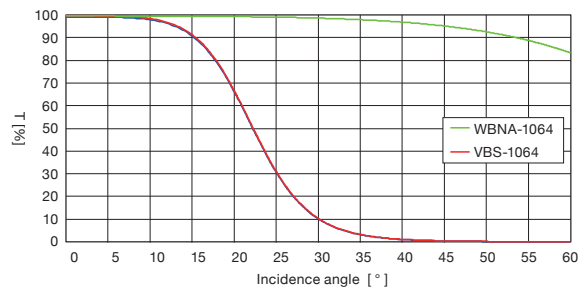
VBS-355 / WSQNA-355



VBS-532 / WBNA-532



VBS-1064 / WBNA-1064

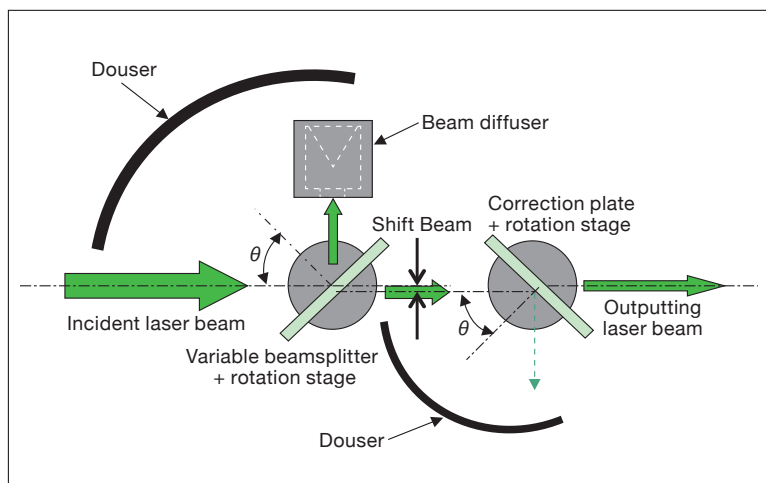


Sample of use

The variable beam splitter can be used individually. When modifying the incident angle, optics thickness and its refractive properties, a shift may occur in the light path. To reduce this shift, we highly recommend a light path corrector. Please see image below.

- Place the variable beamsplitter onto a rotation stage to allow an angle adjustment.
- Install the light path corrector onto a rotating stage.
- Position the light path corrector at a similar angle with the variable beamsplitter on an opposite side.
- If the reflected light of the variable beamsplitter is not used, make sure to place a light cut-off material or a beam diffuser at the edge-end of the light.
- The power of the reflected light from the light path corrector must be cut off at the edge-end of the light.

For part structure, please contact our International Sales Division.



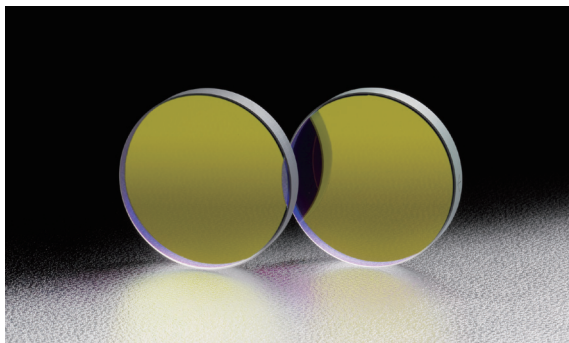
Compatible Optic Mounts

CHA-60, -60F

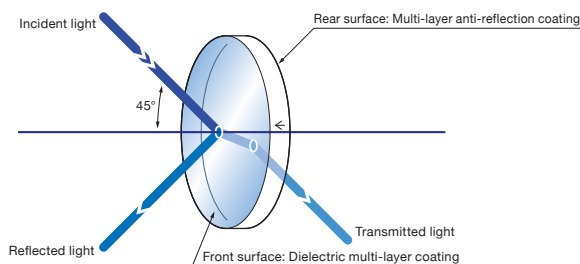
Harmonic separators are part of dichroic mirrors used to separate specific YAG harmonic from other harmonics.

We have prepared three different wavelength reflectance.

- These mirrors are coated with multi-layered dielectric with different refractive index by turns using BK7 optical parallels with $\lambda/10$ surface flatness and parallelism is 5 arc second. The other surface is coated with multi-layer anti-reflection.
- These mirrors are used at 45° incident angle to reflect specific wavelength beam and transmits other wavelength.
- For plate type, you can use a large laser beam diameter.

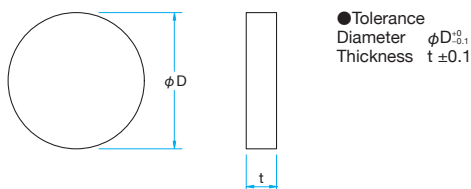


Schematic



Outline Drawing

(in mm)



Specifications

| | |
|-------------------------------|--|
| Material | BK7 |
| Surface Flatness | $\lambda/10$ |
| Coating | Front surface: Dielectric multi-layer coating Rear surface: Multi-layer anti-reflection coating |
| Angle of Incidence | 45° |
| Parallelism | <5" |
| Surface Quality (Scratch-Dig) | 10-5 |
| Clear aperture | 90% of actual aperture |

Guide

- ▶ Please contact our International Sales Division for customized products. (Customized on size, wavelength or R:T, etc.) [Reference](#) B069
- ▶ For a guarantee in reflected wavefront error or transmitted wavefront error, please contact our International Sales Division.

Attention

- ▶ The reflection surface is indicated with an arrow on the side of substrate.
- ▶ The reflectance curves are based on actual measurements and may vary from different manufacturing lots.
- ▶ Be sure to wear laser safety goggles when checking optical path and adjusting optical axis.
- ▶ The reflectance in the specifications list is at random polarization or (p-polarization reflectance + s-polarization reflectance) / 2.

For Reflected wavelength : 355nm, Transmitted wavelength : 532, 1064nm

| Part Number | Diameter ϕD [mm] | Thickness t [mm] | Reflectance at 355nm (The average value of the P-Polarization and the S-Polarization) | | Transmittance at 532·1064nm (The average value of the P-Polarization and the S-Polarization) | | Laser Damage Threshold* [J/cm ²] |
|-----------------|---------------------------|---------------------|--|-----|---|-----|---|
| | | | [%] | [%] | [%] | [%] | |
| YHS-25.4C05-355 | $\phi 25.4$ | 5 | >99.5 | | >85 | | 5 |
| YHS-30C05-355 | $\phi 30$ | 5 | >99.5 | | >85 | | 5 |
| YHS-50C08-355 | $\phi 50$ | 8 | >99.5 | | >85 | | 5 |

*Laser pulse width 10ns, repetition frequency 20Hz

For Reflected wavelength : 532nm, Transmitted wavelength : 1064nm

| Part Number | Diameter ϕD [mm] | Thickness t [mm] | Reflectance at 532nm (The average value of the P-Polarization and the S-Polarization) | | Transmittance at 1064nm (The average value of the P-Polarization and the S-Polarization) | | Laser Damage Threshold* [J/cm ²] |
|-----------------|---------------------------|---------------------|--|-----|---|-----|---|
| | | | [%] | [%] | [%] | [%] | |
| YHS-25.4C05-532 | $\phi 25.4$ | 5 | >99.5 | | >95 | | 8 |
| YHS-30C05-532 | $\phi 30$ | 5 | >99.5 | | >95 | | 8 |
| YHS-50C08-532 | $\phi 50$ | 8 | >99.5 | | >95 | | 8 |

*Laser pulse width 10ns, repetition frequency 20Hz

For Reflected wavelength : 1064nm, Transmitted wavelength : 532nm

| Part Number | Diameter ϕD [mm] | Thickness t [mm] | Reflectance at 1064nm (The average value of the P-Polarization and the S-Polarization) | | Transmittance at 532nm (The average value of the P-Polarization and the S-Polarization) | | Laser Damage Threshold* [J/cm ²] |
|------------------|---------------------------|---------------------|---|-----|--|-----|---|
| | | | [%] | [%] | [%] | [%] | |
| YHS-25.4C05-1064 | $\phi 25.4$ | 5 | >99.5 | | >90 | | 20 |
| YHS-30C05-1064 | $\phi 30$ | 5 | >99.5 | | >90 | | 20 |
| YHS-50C08-1064 | $\phi 50$ | 8 | >99.5 | | >90 | | 20 |

*Laser pulse width 10ns, repetition frequency 20Hz

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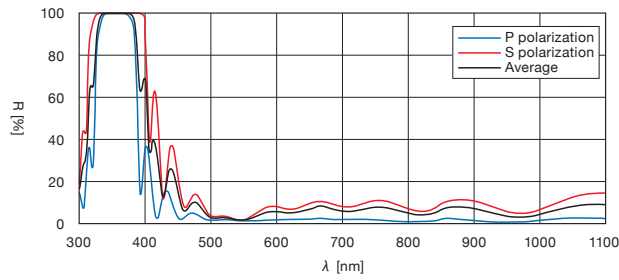
Beam Samplers

Others

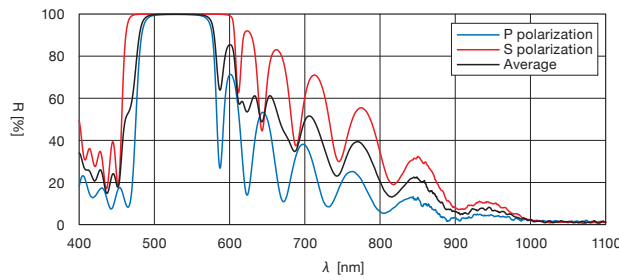
Typical Reflectance Data

R: Reflectance

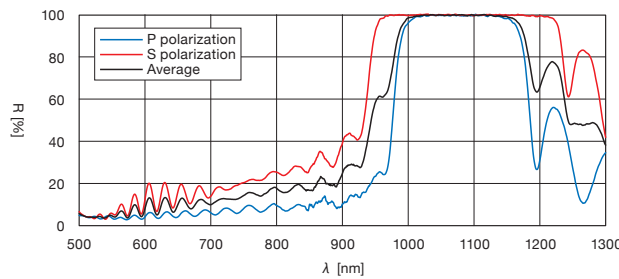
YHS-355



YHS-532



YHS-1064



Compatible Optic Mounts

MHG-HS25-NL, HS30-NL / MHG-PM50-NL / BHAN-30S, -50S

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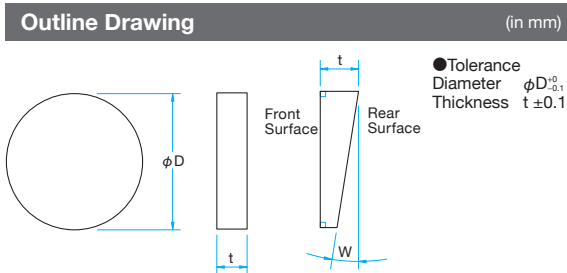
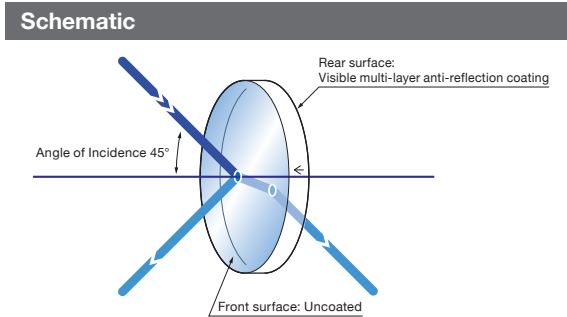
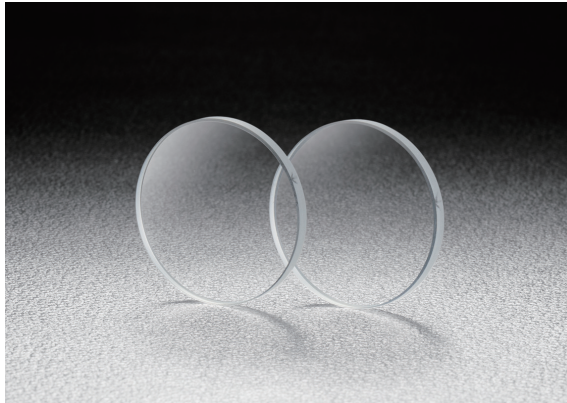
Others

Beam Samplers | BS4

RoHS Catalog Code W3025

A beam sampler behaves like a plate beam splitter, it has the ability to reflect approximately 5.2% of the entire beam.

- Uncoated surfaces of optical parallels or wedged substrates are reflection surfaces. The rear surfaces are coated with multi-layer anti-reflection.
- These products have beam deviations at transmission and ghost by rear surface reflections due to the characteristics of plate beam splitters.
- To prevent ghost, wedged substrate is used with rear surface AR coating.

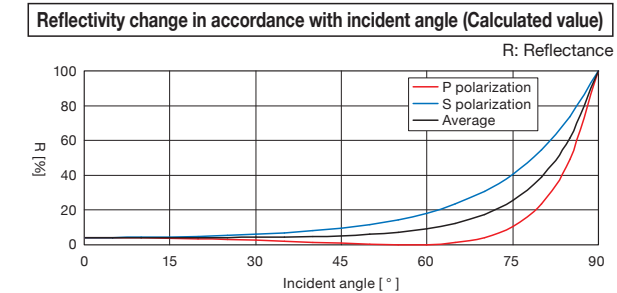
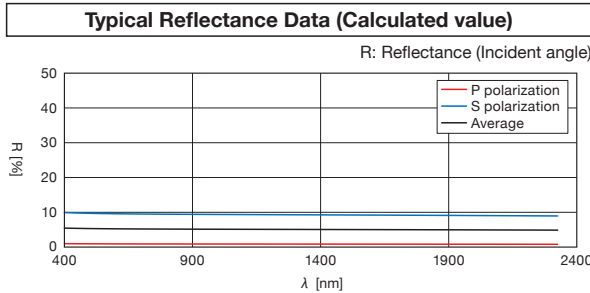
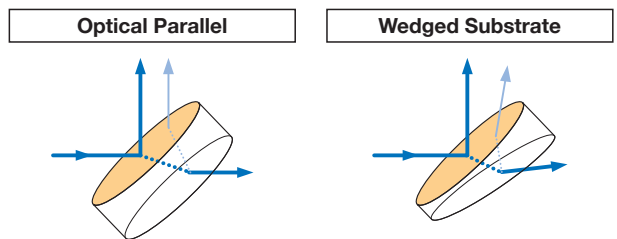


| φ30·φ50 | | | | |
|--------------------|-----------------------|------------------|------------------|---------------|
| Part Number | Wavelength Range [nm] | Diameter φD [mm] | Thickness t [mm] | Parallelism W |
| BS4-25.4C03-10-550 | 400 - 700 | φ25.4 | 3 | <5" |
| BS4-30C03-10-550 | 400 - 700 | φ30 | 3 | <5" |
| BS4-30C05-10W-550 | 400 - 700 | φ30 | 5 | 1°±5' |
| BS4-50C05-10-550 | 400 - 700 | φ50 | 5 | <5" |
| BS4-50C08-10W-550 | 400 - 700 | φ50 | 8 | 1°±5' |

| Specifications | |
|--|--|
| Material | BK7 |
| Surface Flatness | λ/10 |
| Coating | Front Surface: Uncoated Rear Surface: Visible multi-layer anti-reflection coating |
| Incident angle | 45° |
| Divergence ratio (reflectance : transmittance) | 5 : 95 (The average value of the P-Polarization and the S-Polarization) |
| Laser Damage Threshold | 4J/cm ² (Laser pulse width 4ns, repetition frequency 20Hz) |
| Surface Quality (Scratch-Dig) | 10-5 |
| Clear aperture | 90% of actual aperture |

- Guide**
- ▶ Please contact our International Sales Division for customized products. (Customized on size, wavelength or R:T, etc.) [Reference](#) B069
 - ▶ For a guarantee in reflected wavefront error or transmitted wavefront error, please contact our International Sales Division.
 - ▶ An arrow mark will be printed on the thick side of the wedge plate to indicate the surface of the mirror.

- Attention**
- ▶ The reflectance of 5.2% is the value when the material is BK7 and the input beam is unpolarized or circularly polarized.
 - ▶ The beam deviation at transmission of a wedged beam splitter is large compared with beam splitter made of optical parallel.
 - ▶ The amount of beam deviation of a beamsplitter depends on thickness of the substrate and the wavelength/the incident angle of the input beam.
 - ▶ Be sure to wear laser safety goggles when checking optical path and adjusting optical axis.



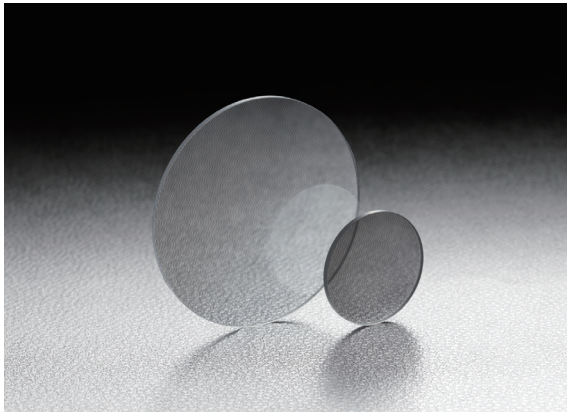
Compatible Optic Mounts

BHAN-30S, -50S / MHG-MP25-NL, MP30-NL

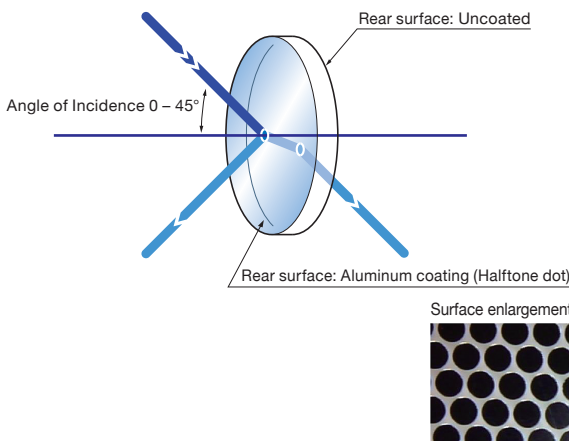
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The polka dot beam splitter is a beam splitter that has been made by the aluminum coating of halftone dots (polka dots) on the glass substrate. It has a low dependence on the incident angle and can be used in a wide range of wavelengths from ultraviolet region to infrared region.

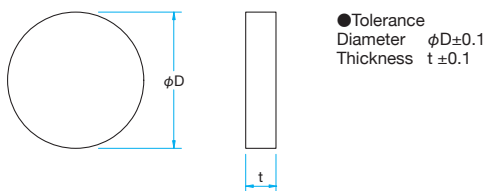
- Reflectance to transmittance ratio has been adjusted by the area ratio of the points that have been coated.
- Unlike the beam splitter of the dielectric type, in spite of the change in the incident angle, the reflectance and transmittance ratio does not alter.
- There are two types of the outer diameter like $\phi 25.4\text{mm}$ and $\phi 50.8\text{mm}$ and three types of reflectance to transmittance ratio such as 7:3, 5:5 and 3:7.



Schematic



Outline Drawing



Specifications

| | |
|--------------------------------|--|
| Material | Synthetic fused silica |
| Parallelism | <3' |
| Coating | Front Surface: Al+MgF ₂ Rear Surface: Uncoated |
| Recommended angle of incidence | 0 – 45° |
| Wavelength range | 250 – 2200nm |
| Surface Quality (Scratch-Dig) | 80-50 |
| Dot pitch | 0.3mm |
| Clear aperture | Circle except surrounding 1.5mm |

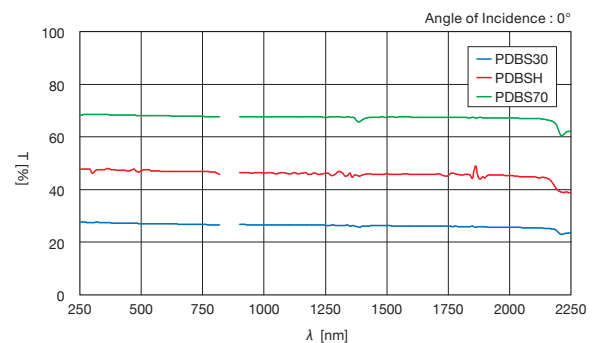
Guide

► We can also offer different sizes, wavelengths and branching ratios that are not mentioned in the catalog. [Reference](#) B069

Attention

- When used with a laser beam with high interference, diffraction occurs.
 - When light is incident, scattering light by the halftone dot occurs.
 - By the effect of the refractive index and the thickness of the substrate, the optical path of the transmitted light over the incident light will move by 0.5 extent parallel.
 - When the incident beam diameter is very thin, it is not possible to separate into the split ratio.
 - Do not clean with water or solvents. It may cause surface deterioration.
 - Please use in the environments which are non-condensing and less dust.
- If the dust or dirt is deposited, please do not blow but blow it off gently with dried air.

Typical Transmittance Data



Specifications

| Part Number | Reflectance : Transmittance | Diameter ϕD [mm] | Thickness t [mm] | Transmission (Wavelength Range 555nm, Angle of Incidence : 0°) [%] |
|-----------------|-----------------------------|------------------------|------------------|--|
| PDBS70-25.4C1.5 | 70 : 30 | $\phi 25.4$ | 1.5 | 30% |
| PDBS70-50.8C1.5 | 70 : 30 | $\phi 50.8$ | 1.5 | 30% |
| PDBSH-25.4C1.5 | 50 : 50 | $\phi 25.4$ | 1.5 | 50% |
| PDBSH-50.8C1.5 | 50 : 50 | $\phi 50.8$ | 1.5 | 50% |
| PDBS30-25.4C1.5 | 30 : 70 | $\phi 25.4$ | 1.5 | 70% |
| PDBS30-50.8C1.5 | 30 : 70 | $\phi 50.8$ | 1.5 | 70% |

Compatible Optic Mounts

P25-NL, MP50.8-NL / MHAN-25.4S, -50.8S

Pellicle beam splitter | PELL

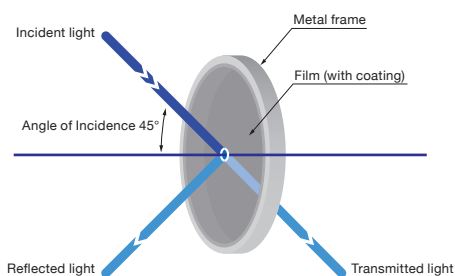
RoHS

By using the thin film in (as) a beam splitter, it is possible to remove the shift of the transmitted beam and the ghost image due to backside reflection. In addition, it can also be used without changing the wavelength dispersion in ultrashort pulse laser, to separate laser beam.

- Since it is used a thin film with a thickness of 2μm or less, (Therefore) in case of the absence of the film the difference of optical path length (between the absence of the film) will be controlled to (less than) 1μm or less.
- It does not (is never) occur that the beam will be divided into two by the back reflection and surface reflection. And the ghost of back reflection will not occur to the image being reflected by the pellicle.
- Because it can be used at high effective diameter of $\phi 101.6\text{mm}$, it can also be used to a large optical system of the effective diameter.
- It is available to provide such as;
 - “PELL50” the dielectric multilayer coating that will divide into the (1:1) transmittance and reflectance at a 1:1 ratio,
 - “PELL40” chromium film that has a small change in the dividing (branching) ratio of the transmittance and reflectance due to the wavelength. (is small.)
 - “PELL33” a dielectric multilayer coating that will (to) divide (branch) into the (1:2 ratio) transmittance and reflectance at a 1:2 ratio, and “PELL10” can be used as a beam sampler.

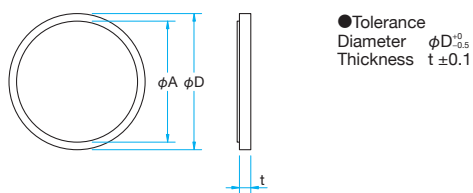


Schematic



Schematic

(in mm)



Specifications

| | |
|------------------------------------|--|
| Material | Nitrocellulose film |
| Thickness of film | <2μm |
| Refractive index | 1.5 |
| Transmitted wavefront distribution | 2λ (φ25.4mm) |
| Wavelength Range | 633nm |
| Coating | PELL10: Uncoated PELL40: Chromium film (Inconel) PELL33, PELL50: Dielectric Multilayer coating |
| Incident angle | 45° |
| Material of frame | Aluminum Surface treatment: black alumite anodized |
| Surface Quality (Scratch-Dig) | 40-20 |

Attention

- ▶ Pellicle is very easy to tear. Do not press with your fingers and poke with pointed objects.
- ▶ Pellicle is easy to be scratched. Do not rub with the paper. Please blow dirt or dust off with an air duster.
- ▶ Because this film is an organic, it can not be used for high-power laser.
- ▶ Because it is a product that has stuck to the film, there is a possibility that the beam of reflected light is divergence or convergence.
- ▶ When it is used in large beam, interference fringes due to the front and back side surface will occur in the reflected beam.

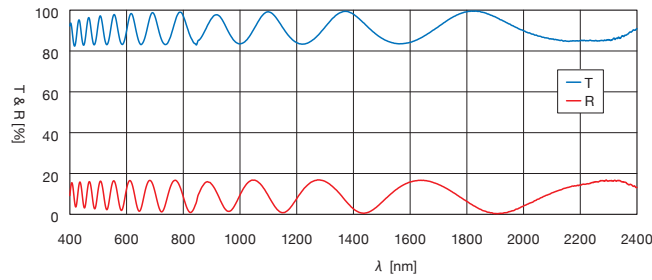
Specifications

| Part Number | Diameter φD [mm] | Clear aperture φA [mm] | Thickness t [mm] | Reflectance at 632.8nm (The average value of the P-Polarization and the S-Polarization) | | Transmittance at 632.8nm (The average value of the P-Polarization and the S-Polarization) | |
|------------------|------------------------|------------------------------|------------------------|--|-----|--|-----|
| | | | | [%] | [%] | [%] | [%] |
| PELL10-34.9-633 | φ34.9 | φ25.4 | 4.8 | 8 | 92 | | |
| PELL10-63.5-633 | φ63.5 | φ50.8 | 6.4 | 8 | 92 | | |
| PELL10-114.3-633 | φ114.3 | φ101.6 | 6.4 | 8 | 92 | | |
| PELL33-34.9-633 | φ34.9 | φ25.4 | 4.8 | 33 | 67 | | |
| PELL33-63.5-633 | φ63.5 | φ50.8 | 6.4 | 33 | 67 | | |
| PELL33-114.3-633 | φ114.3 | φ101.6 | 6.4 | 33 | 67 | | |
| PELL40-34.9-633 | φ34.9 | φ25.4 | 4.8 | 40 | 40 | | |
| PELL40-63.5-633 | φ63.5 | φ50.8 | 6.4 | 40 | 40 | | |
| PELL40-114.3-633 | φ114.3 | φ101.6 | 6.4 | 40 | 40 | | |
| PELL50-34.9-633 | φ34.9 | φ25.4 | 4.8 | 50 | 50 | | |
| PELL50-63.5-633 | φ63.5 | φ50.8 | 6.4 | 50 | 50 | | |
| PELL50-114.3-633 | φ114.3 | φ101.6 | 6.4 | 50 | 50 | | |

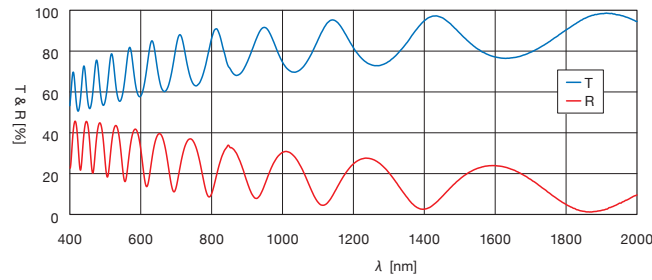
Typical Reflectance Data & Typical Transmittance Data

T: Transmission R: Reflectance

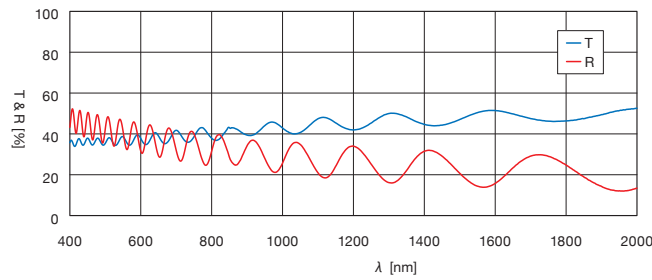
PELL10-633



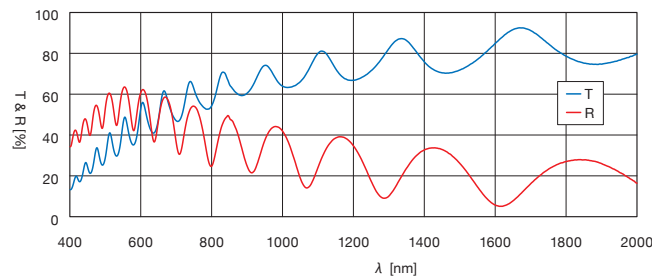
PELL33-633



PELL40-633



PELL50-633



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